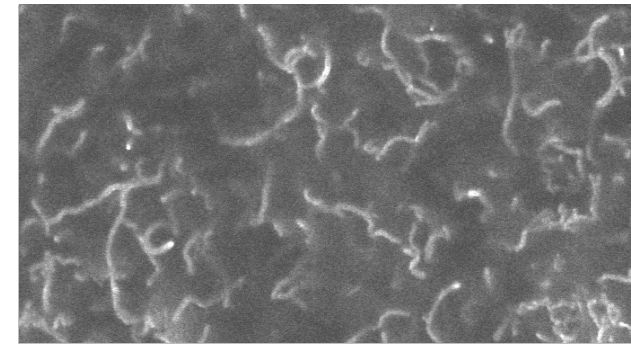
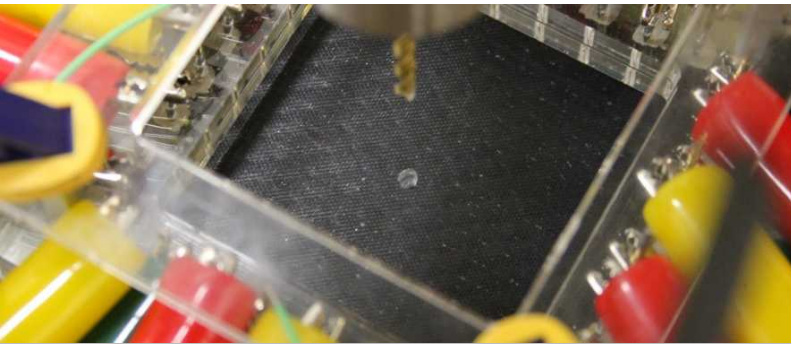


Exceptional service in the national interest



Spatially Distributed Structural Health Monitoring using Electrical Impedance Tomography

Bryan R. Loyola¹

¹Sandia National Laboratories, Livermore, CA, USA



Sandia National Laboratories is a multi-program laboratory managed and operated by Sandia Corporation, a wholly owned subsidiary of Lockheed Martin Corporation, for the U.S. Department of Energy's National Nuclear Security Administration under contract DE-AC04-94AL85000. SAND NO. 2011-XXXXP



Usage of Fiber-Reinforced Composites

- Over the past 50 years, increased usage of composite materials



Commercial aircraft systems



Future and legacy spacecraft



Military aircraft



Naval structures



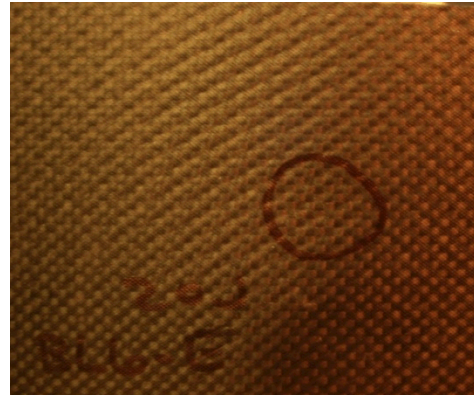
Wind turbine blades



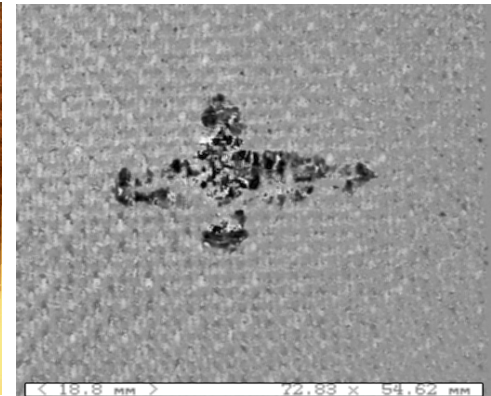
CFRP cable stay bridge

Composite Damage Modes

- Susceptible to damage due to:
 - Strain, impact, chemical penetrants, multi-axial fatigue
- Damage modes:
 - Matrix cracking
 - Fiber-breakage
 - Delamination
 - Transverse cracking
 - Fiber-matrix debonding
 - Matrix degradation
 - Blistering
- Difficult to detect
 - Internal to laminate structure
 - Nearly invisible to naked eye
 - Current methods are laborious



Visual inspection



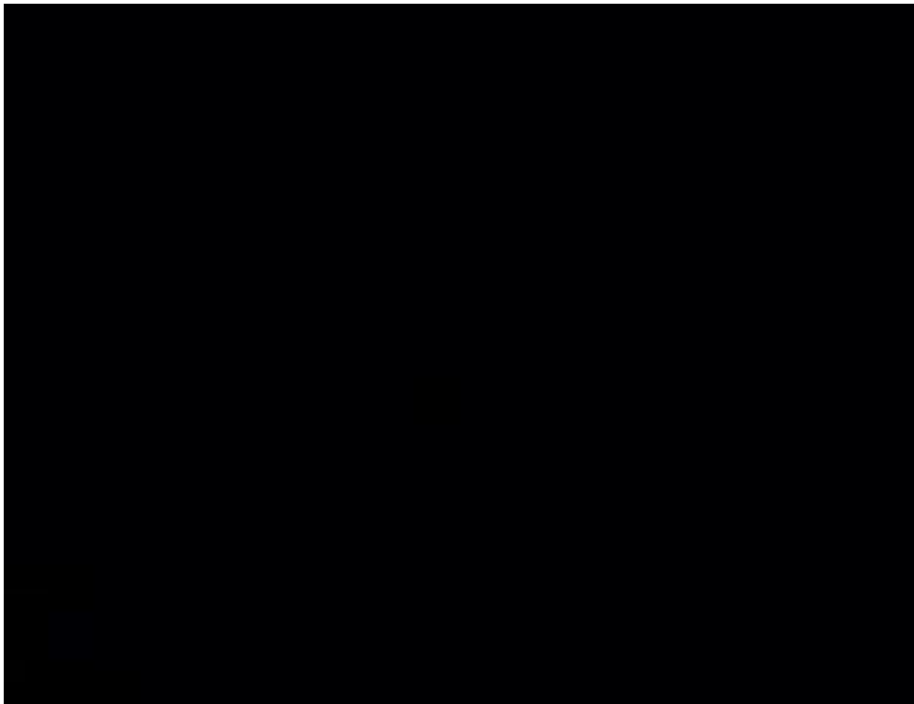
C-SCAN ultrasound image

CFRP panel after 20 Joule impact



Aircraft ultrasonic inspection (Composites World)

Catastrophic Failure



- Occurred in 2002 – one of the worst fire seasons in previous 50 yrs.
- Event caused grounding of fleet (33 aircraft) severely reducing resources
- [Wikipedia](#)

- Reliability Engineering
 - Replacement based on predetermined max lifetime/lifecycles
 - High cost
 - F-35 maintenance will cost est. \$1.1T during lifetime



F-35A Lightning II (Lockheed Martin)

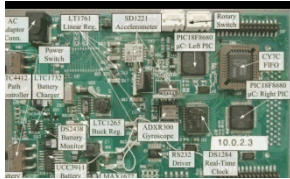
- Reliability paradigm shift
 - Event driven replacement
 - Lower cost
 - Save lives

Emerging Sensing Technologies

Wireless Sensors and Sensor Networks

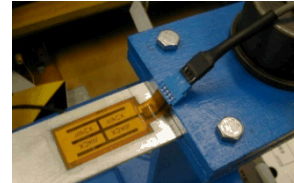
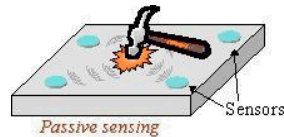


WiMMS



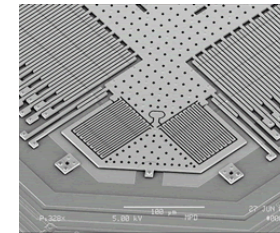
UCI DuraNode

Ultrasonics and Guided-Waves

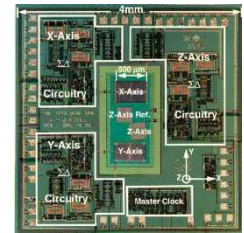


Array of piezoelectric ceramic sensors and actuators

Micro-electromechanical Systems (MEMS)



AD iMEMS
Weinberg (1999)



3-axis accelerometer
Lemkin (1997)

Advantages:

-
-
-

Disadvantages:

-
-
-

FIX

Strain gages, DIC, fiber optics, embedded piezos

Advantages:

- Sensors and actuators
- Spatial damage detection

Disadvantages:

- Indirect damage detection
- Wave propagation models or pattern recognition
- Thin structures
- Expensive data acquisition

Advantages:

- Miniaturized sensor designs
- Complex sensors/actuators

Disadvantages:

- "Top-down" design
- Expensive fabrication equipment
- High costs
- Sensor sensitivity on par with macro-scale counterpart

SHM Design Considerations

Current SHM limitations:

- Indirect sensing approaches
- Point-based sensing
- Tethered sensors
- Lack of system scalability



Boeing 787 (Boeing)

Successful SHM systems:

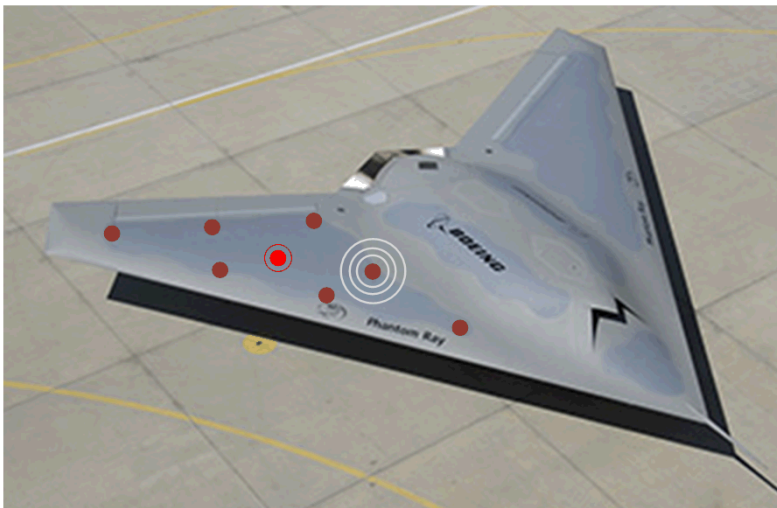
1. Directly detect and measure damage
2. Determine the damage location
3. Ascertain the size of the damage
4. Quantify the severity of the damage
5. Achieve multi-modal sensing capabilities (i.e., delamination, cracking, and chemical penetration)



Golden Gate Bridge (Wikipedia)

Spatially Distributed SHM Paradigm

- Current state-of-art in structural health monitoring:
 - Passive SHM using acoustic emissions
 - Active SHM using piezoelectric sensor/actuator pairs
- “Sensing skins” for spatial damage detection:
 - Objective is to identify the location and severity of damage
 - Monitor and detect damage over two- (or even three) dimensions
 - Direct damage detection

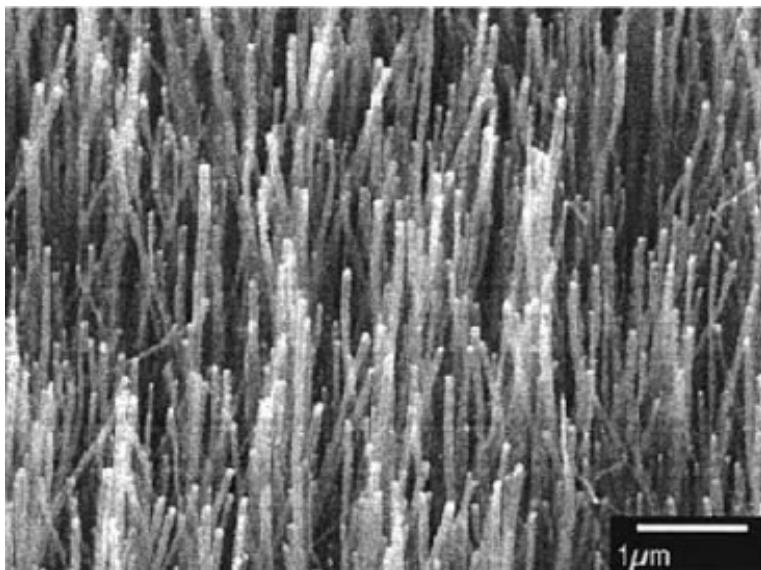


(Boeing)

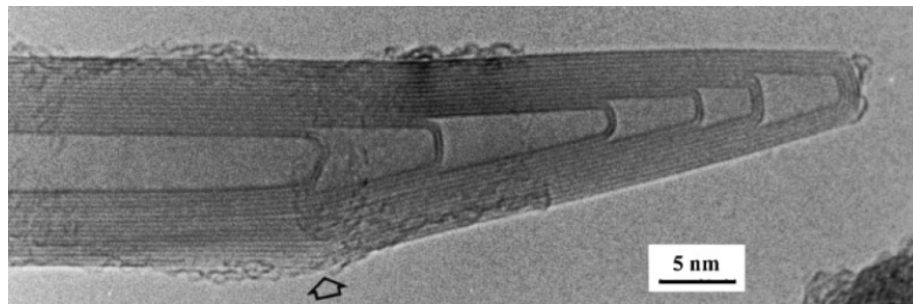
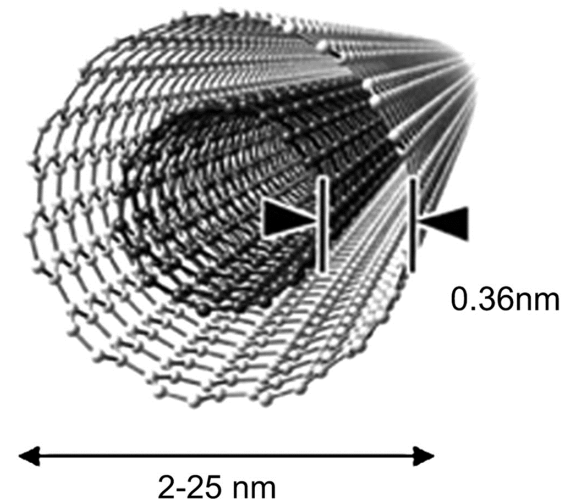


(Boeing)

- Multi-walled carbon nanotubes (MWNT):
 - Rolled concentric cylindrical structures constructed of graphene sheets
 - Diameter: 6 ~ 100 nm
 - High-aspect ratios: $\sim 10^3$ to 10^7
 - Metallic conductivity
 - Five times stiffer and ten times stronger than steel



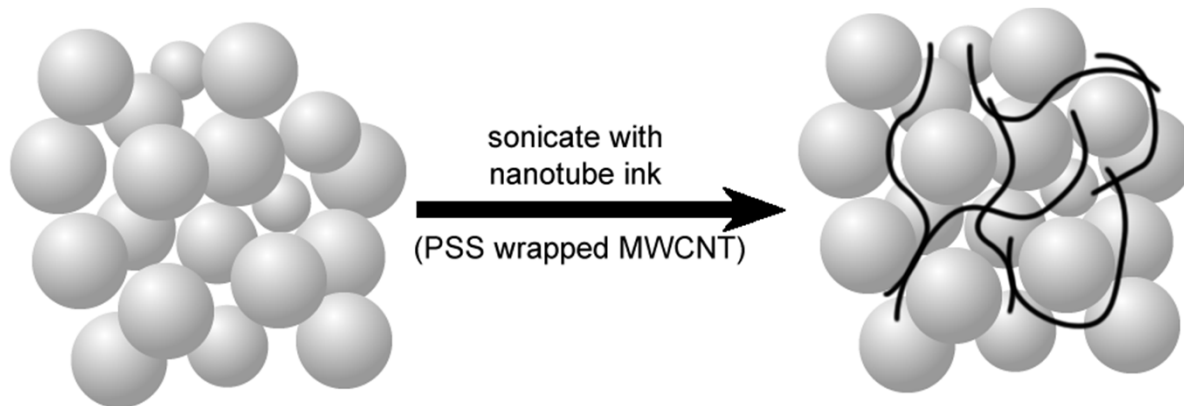
Aligned carbon nanotube forest
Thostenson, et al. (2001)



TEM imagery of an end cap of a MWNT
Harris (2004)

Sprayable MWNT-Latex Thin Film

- Rapid large-scale deposition
 - Required for mass deployment of methodology
- MWNT-PSS/Latex paint formulation
 - Collaborated to improve initial Sandia formulation
 - Sub-micron PVDF creates mold for MWNT organization
 - Off-the-shelf deposition method

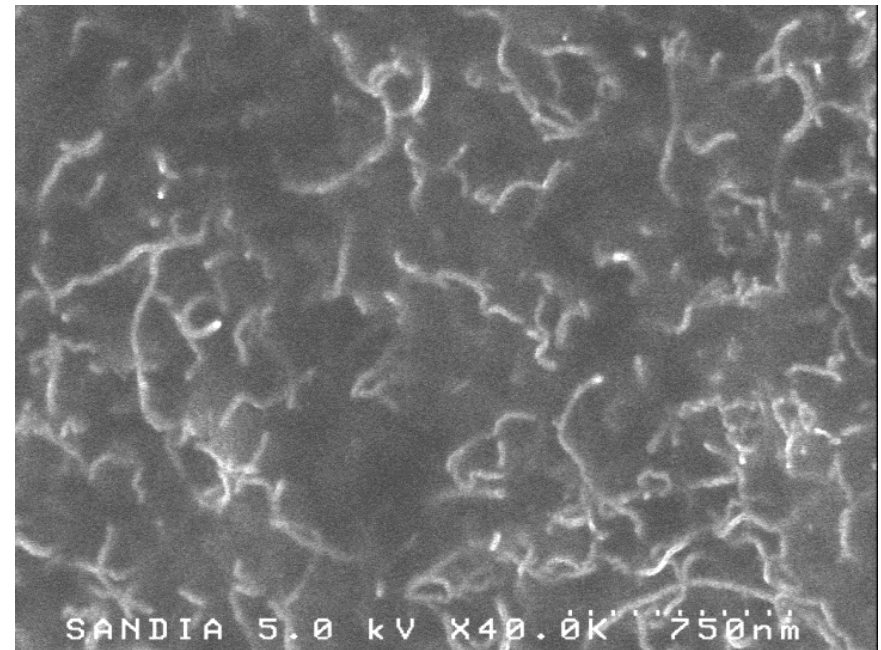
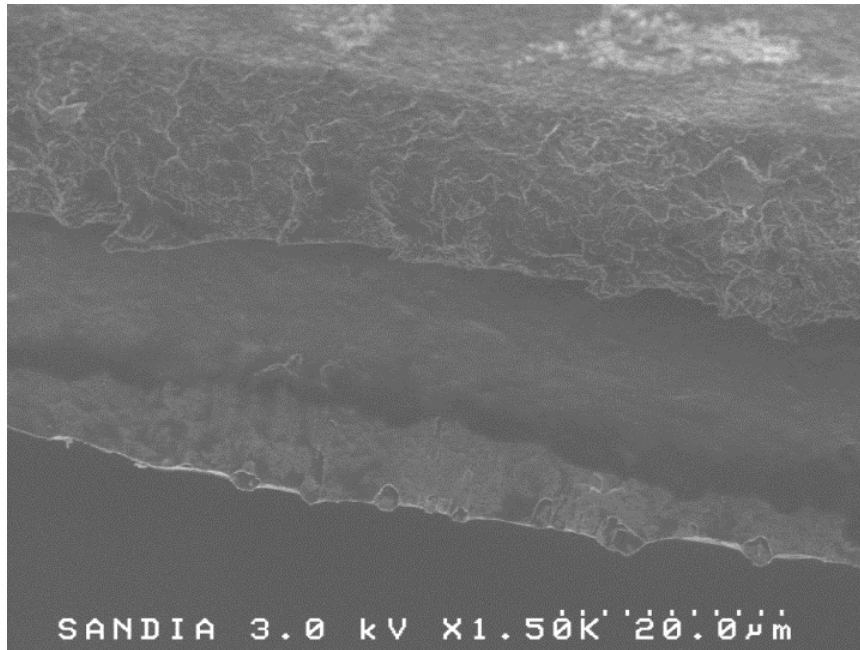


Kynar Aquatec™ latex solution
(avg. particle size 150nm)

Forms segregated
MWCNT network

MWNT-Latex Morphology

- Creation of MWNT networks:
 - Electrical percolation above 1 wt% MWNTs
- Fiber-reinforced polymer deployment:
 - Surface applied to post-cured composites
 - Applied to fiber weaves for embedded sensing



Cross-section and MWNT network SEM images of 3wt% MWNT-Latex film

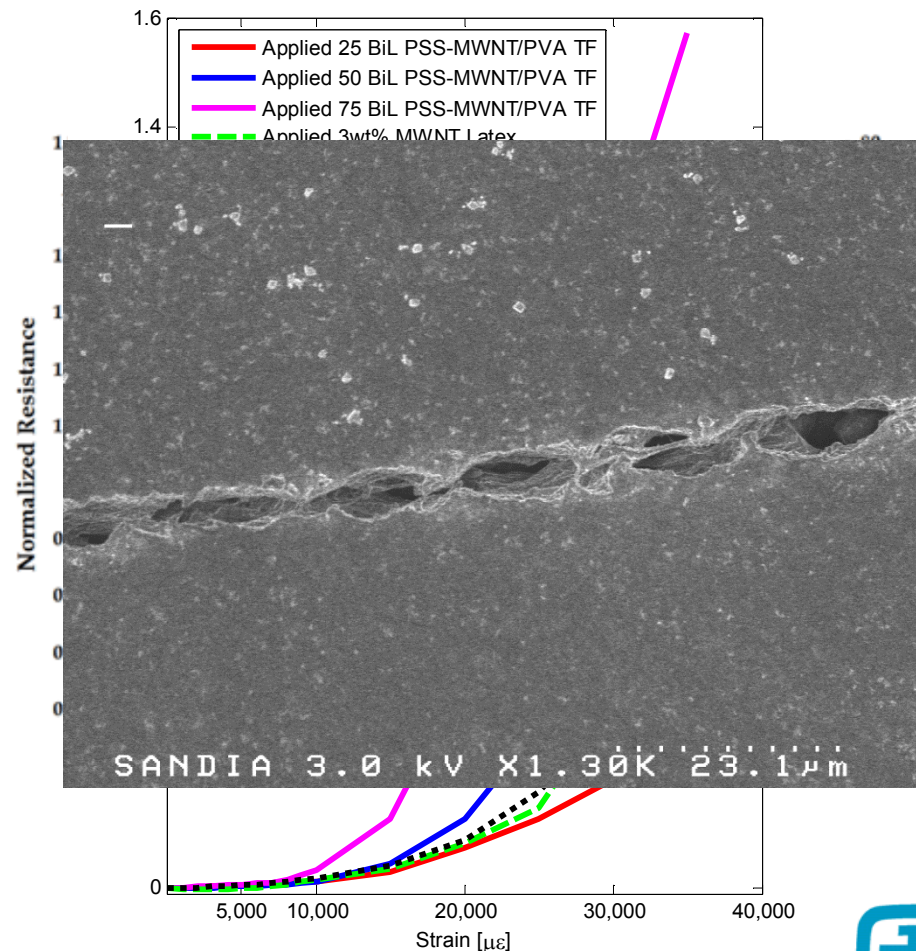
MWNT-Latex Characterization

- Electromechanical characteristics:

- Quasi-static testing
 - Nearly same sensitivity as LbL
- Bi-functional strain response
 - Linear
 - Quadratic
 - Cracking of film

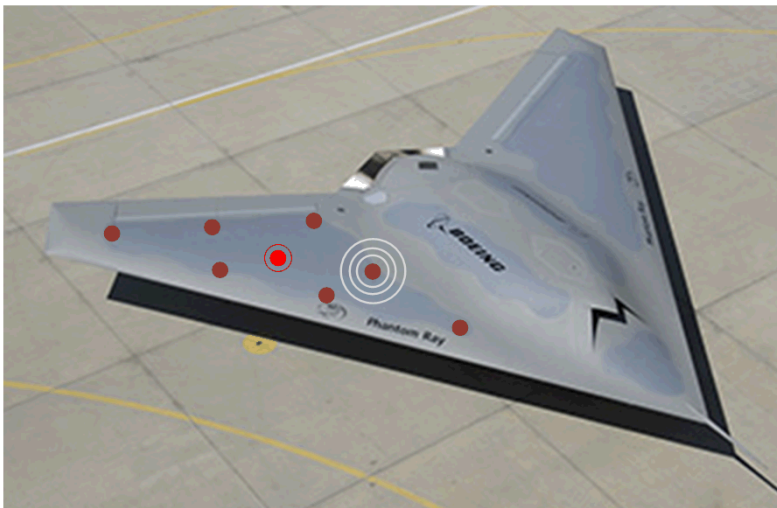
- Thermo-resistance coupling:

- -50°C to 80°C over 2 hours
- 2 hour holds
- Inversely linear relationship
- Non-linear response @ -30°C
 - $\sim T_g$ of PVDF
 - Restructuring of MWNTs



Spatially Distributed SHM Paradigm

- Current state-of-art in structural health monitoring:
 - Passive SHM using acoustic emissions
 - Active SHM using piezoelectric sensor/actuator pairs
- “Sensing skins” for spatial damage detection:
 - Objective is to identify the location and severity of damage
 - Monitor and detect damage over two- (or even three) dimensions
 - Direct damage detection



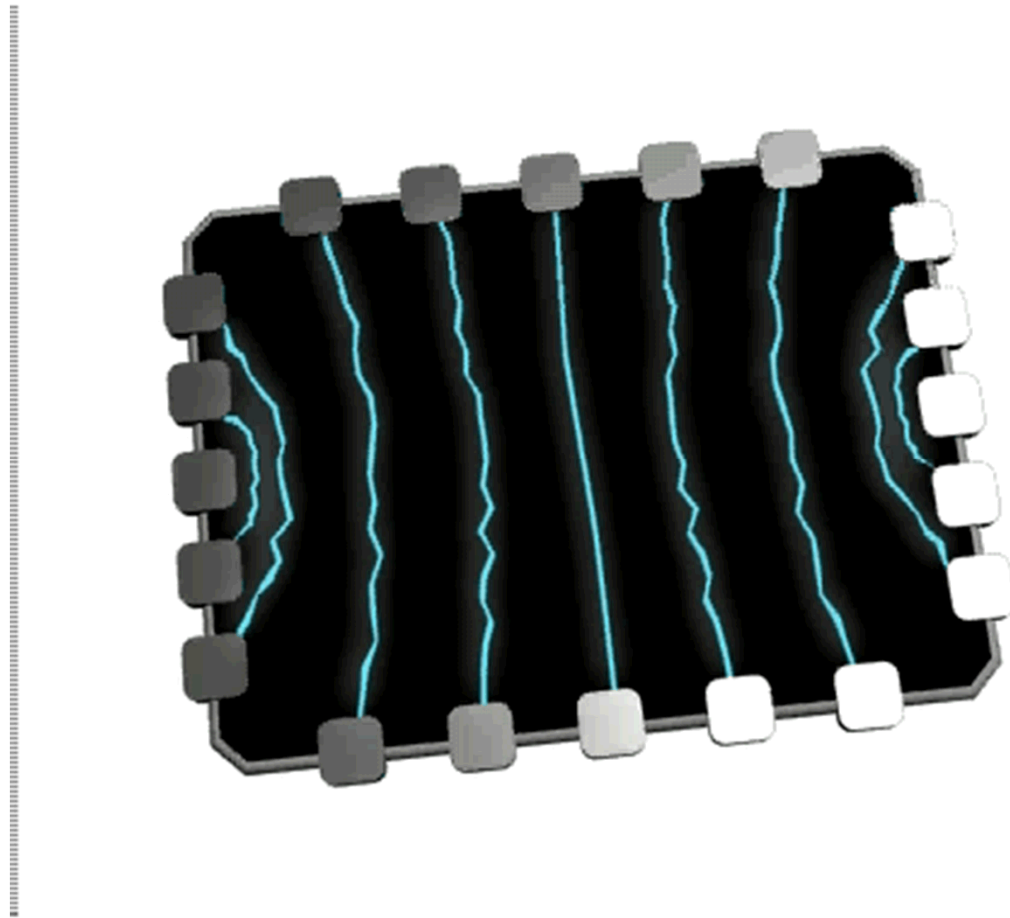
(Boeing)

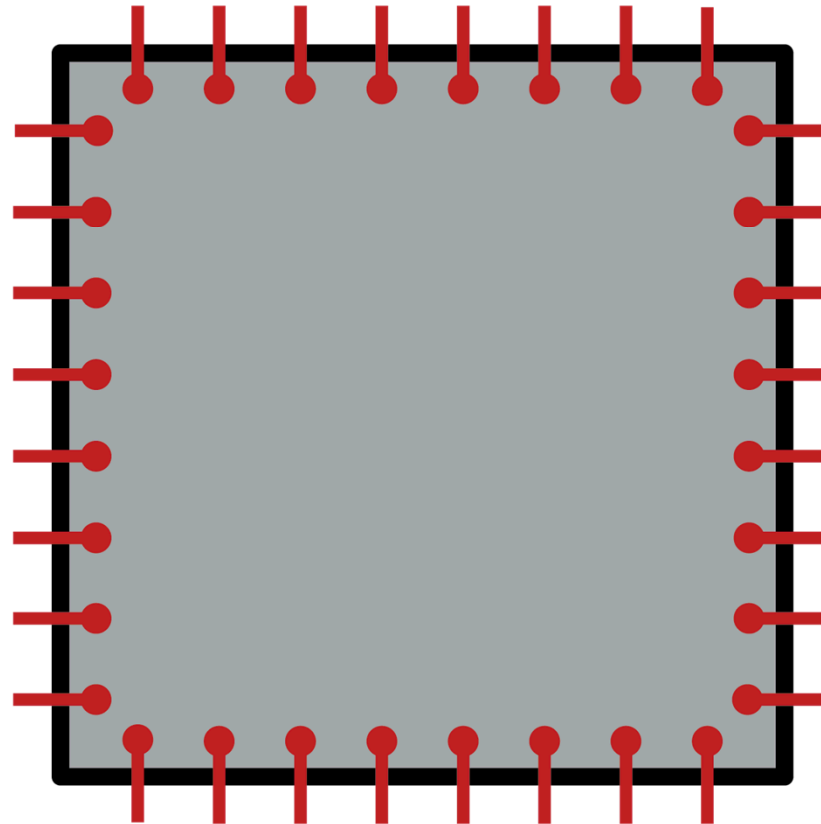


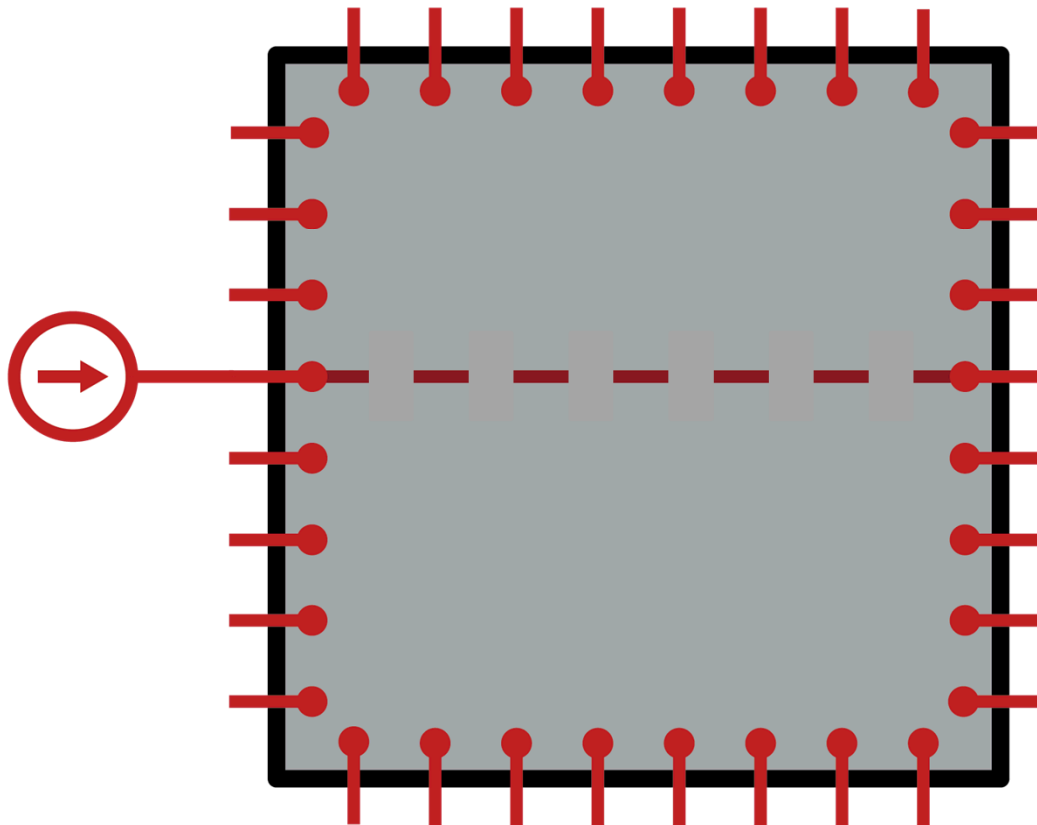
(Boeing)

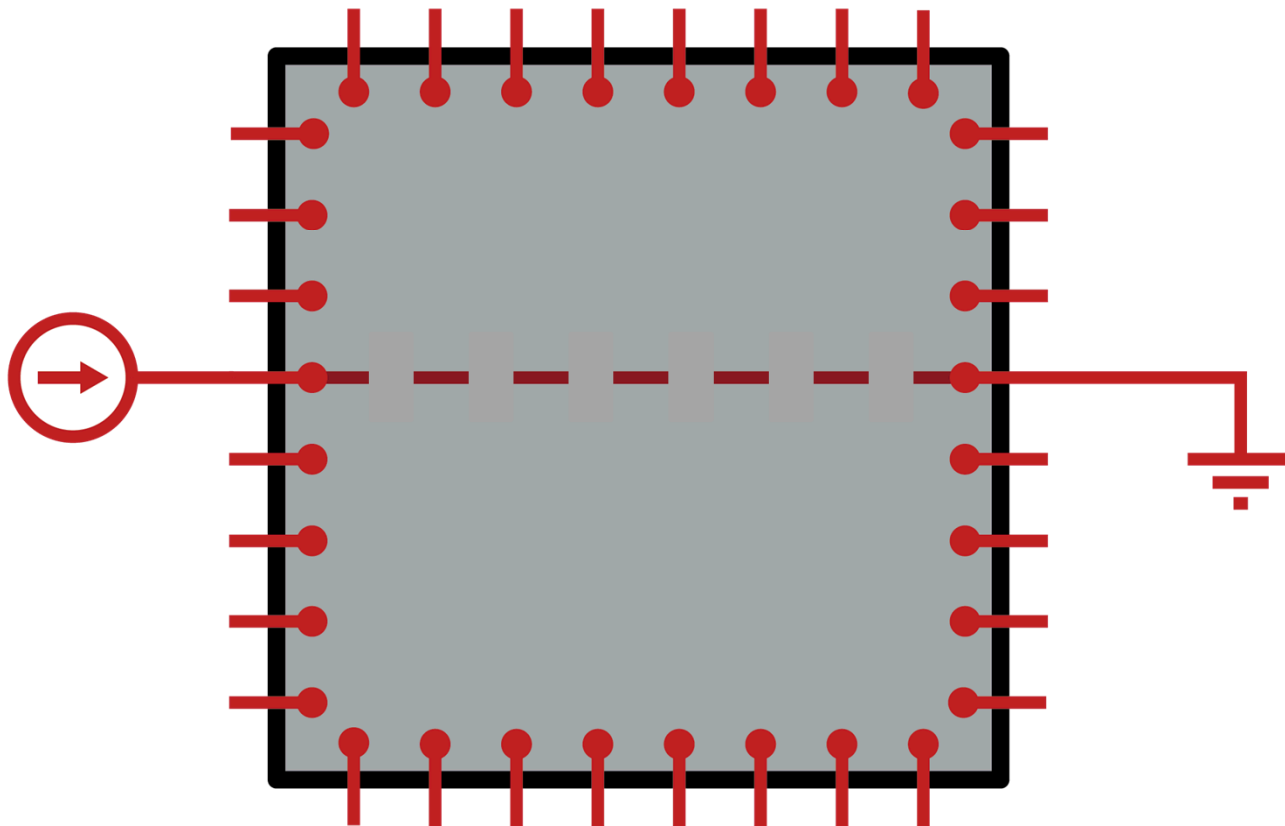
Electrical Impedance Tomography

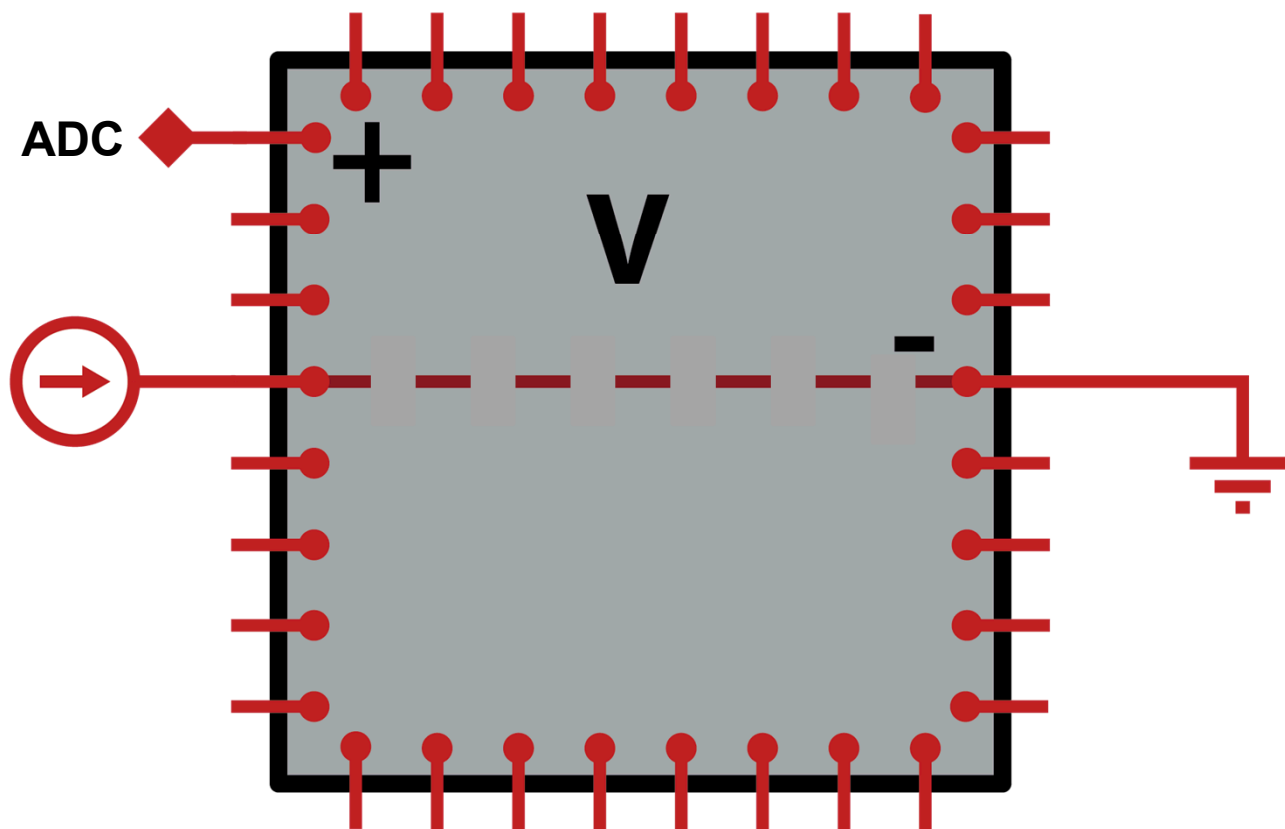
- Overview of spatial conductivity mapping
 - Since film impedance calibrated to strain, conductivity maps can correspond to 2-D strain distribution maps

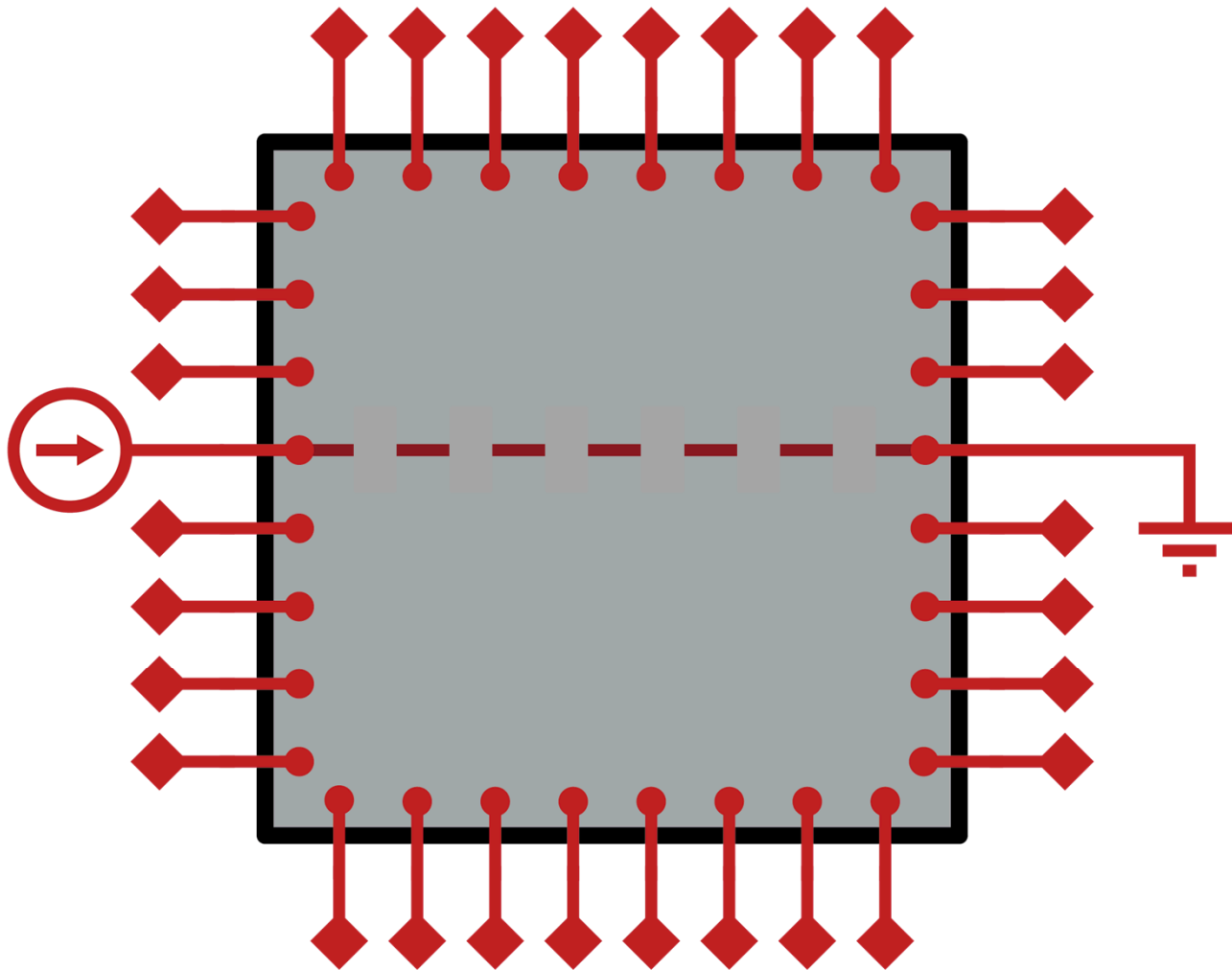


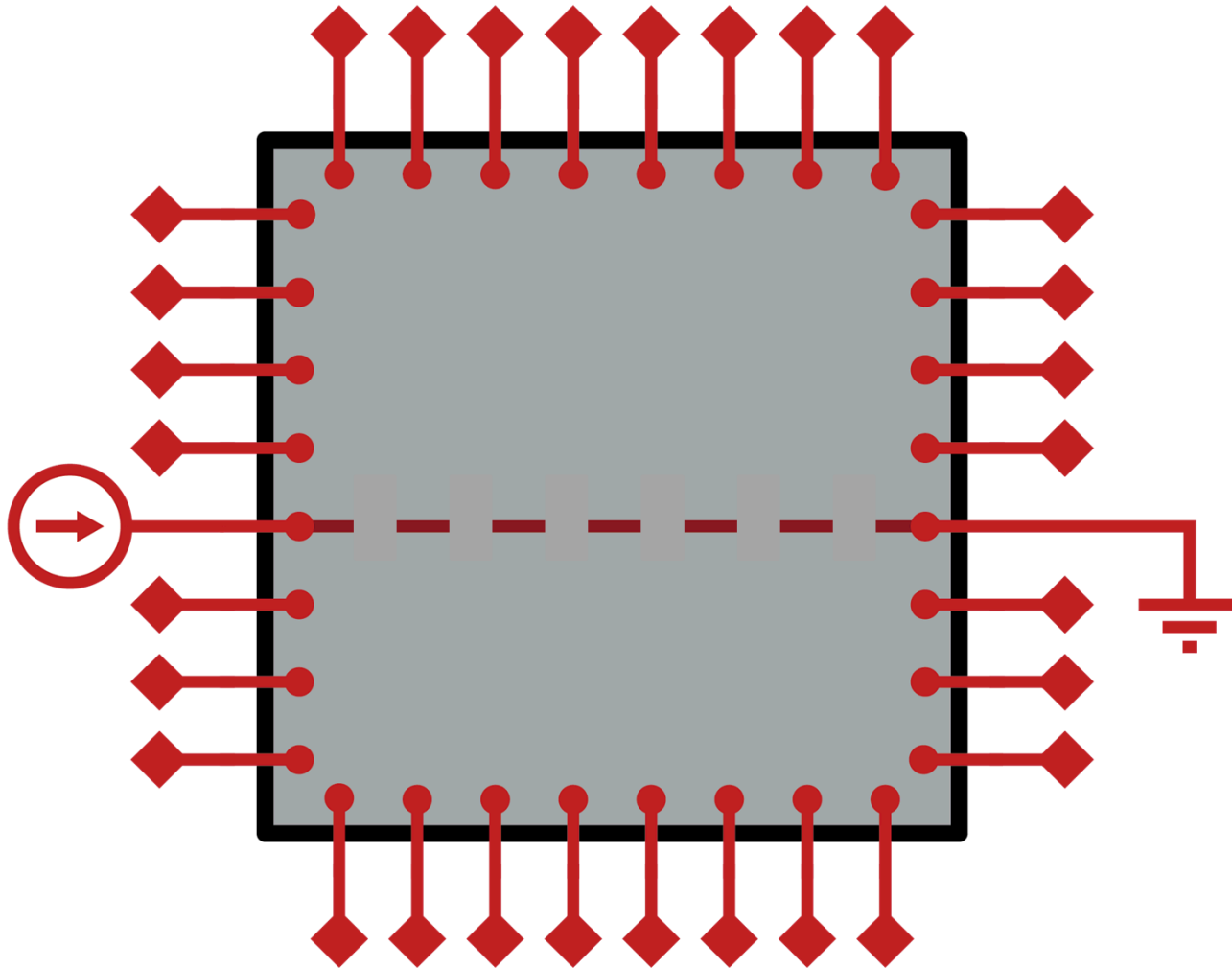


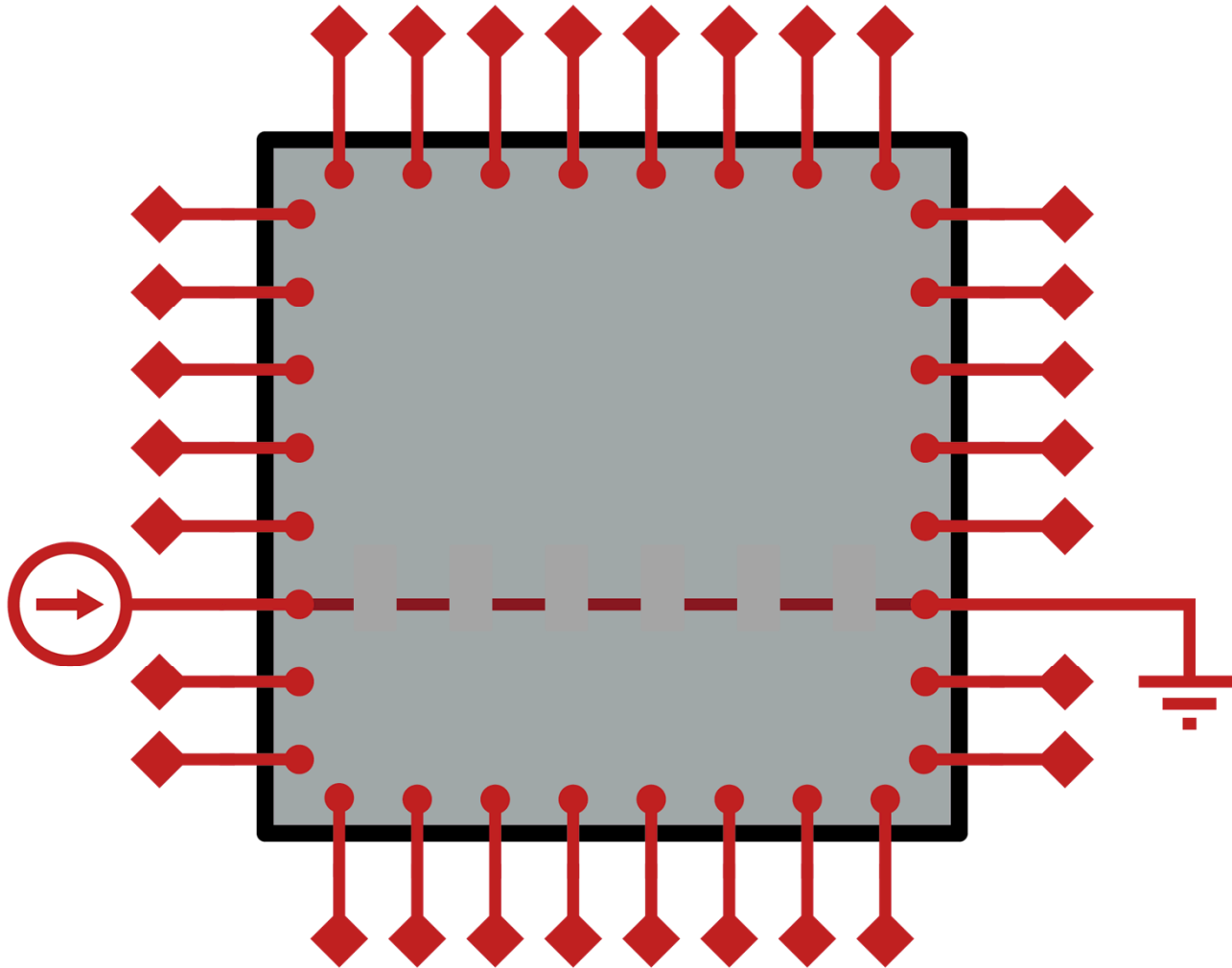




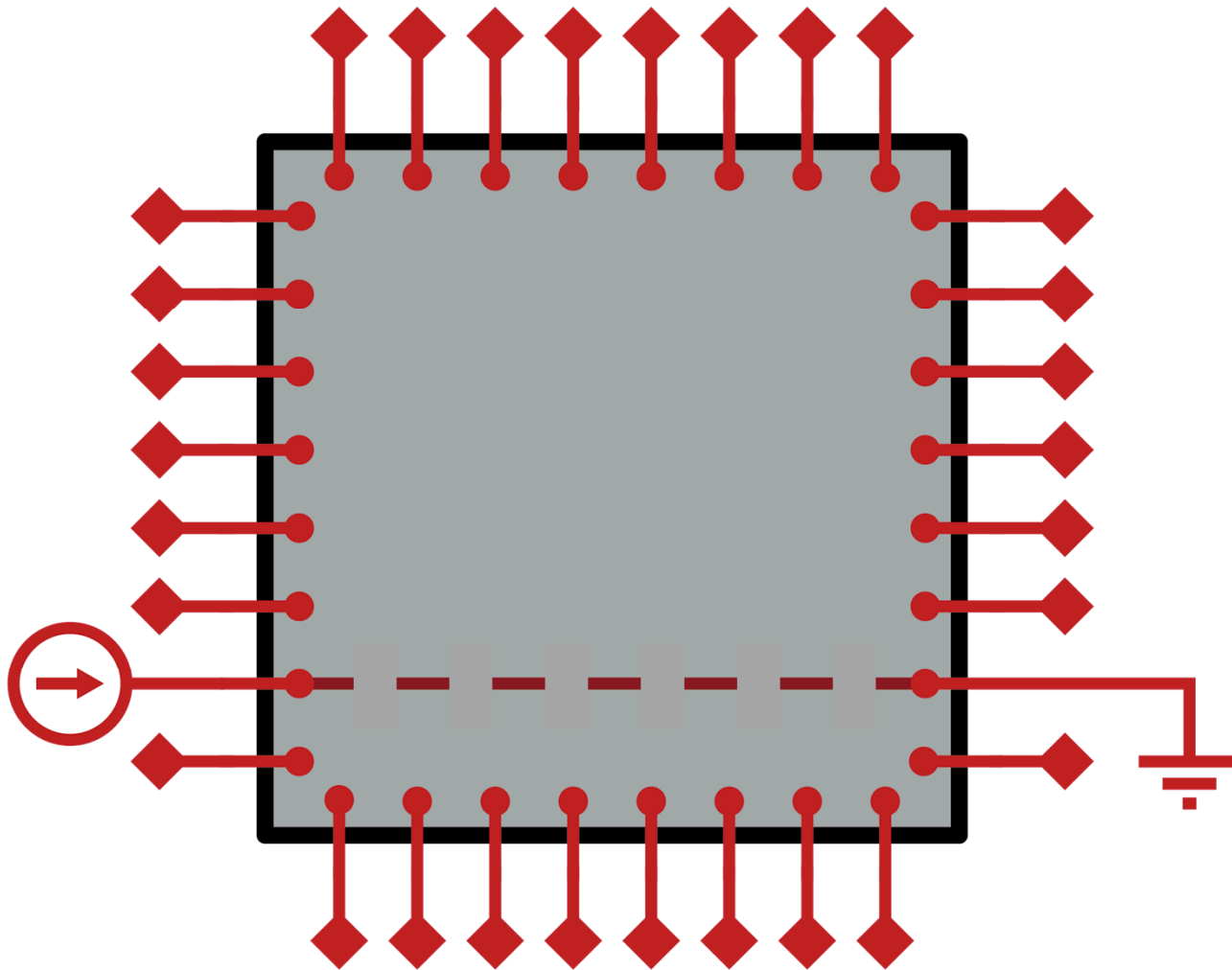








EIT Measurements

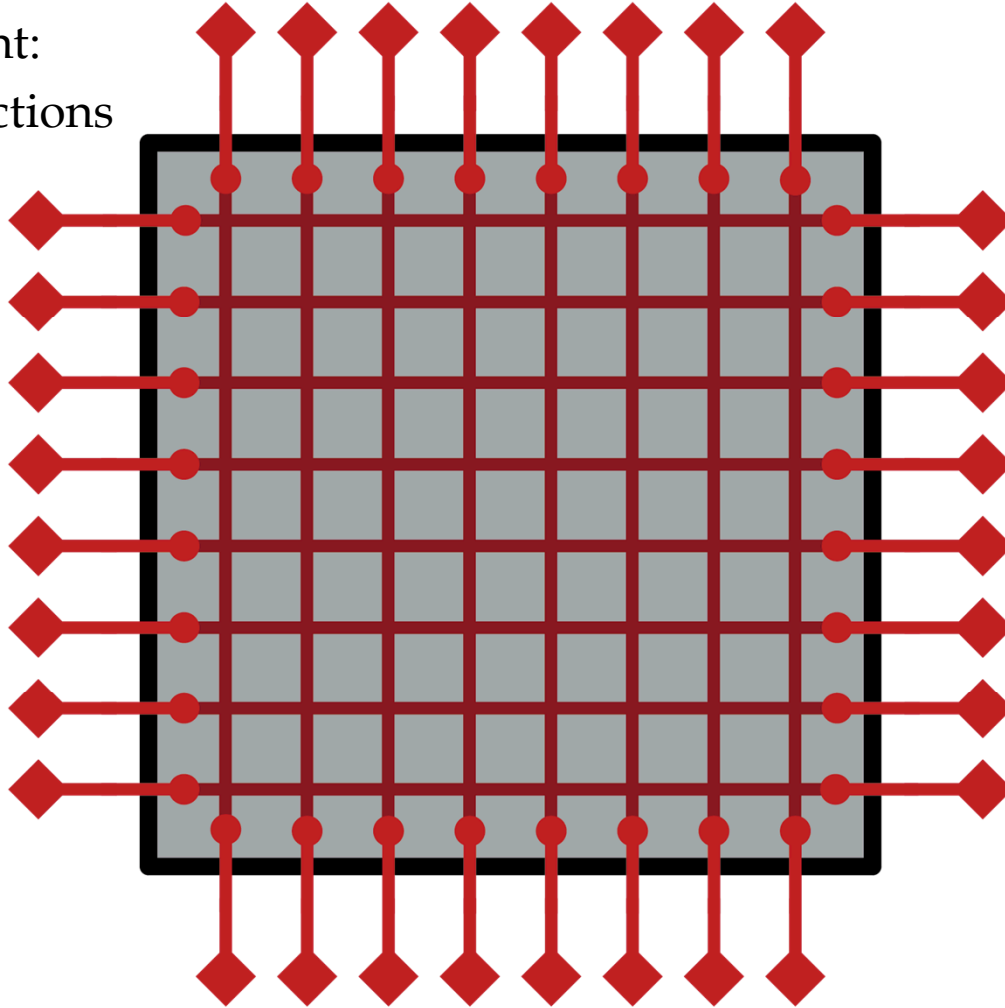


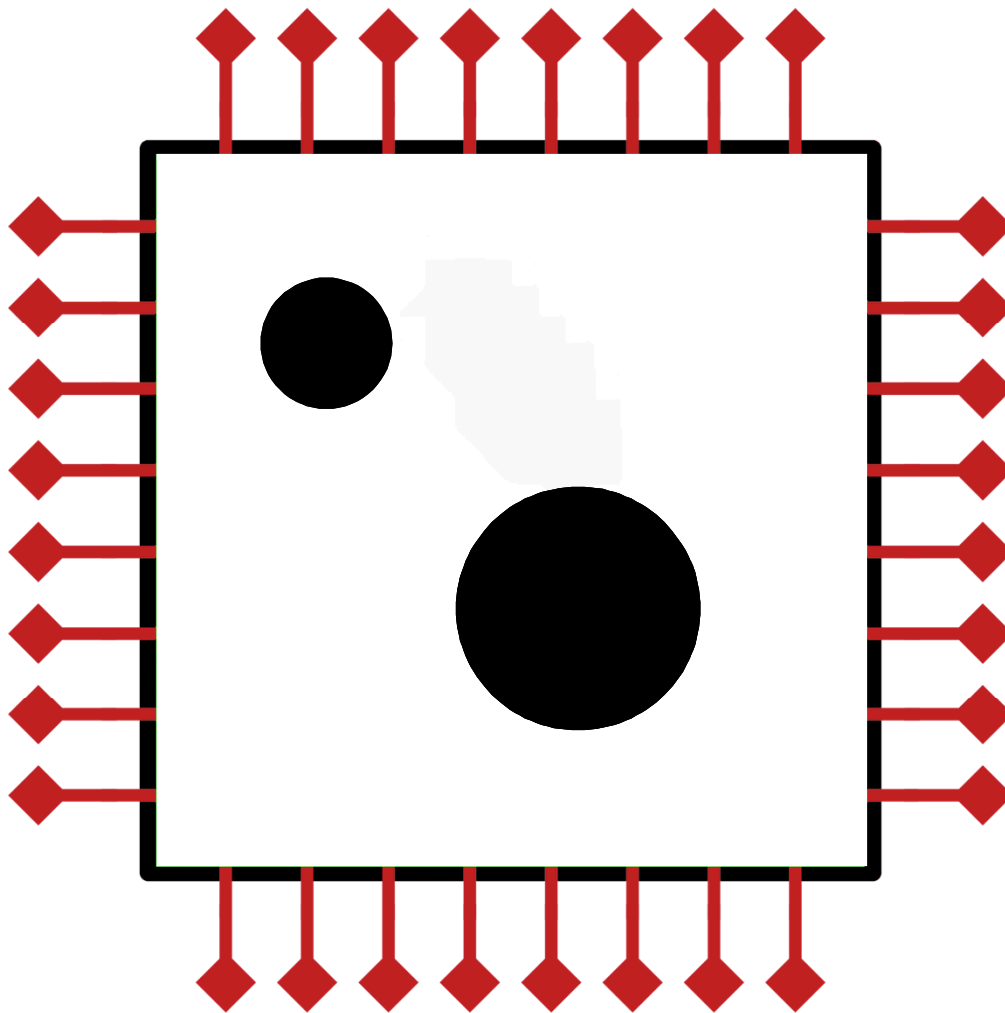
EIT Measurements

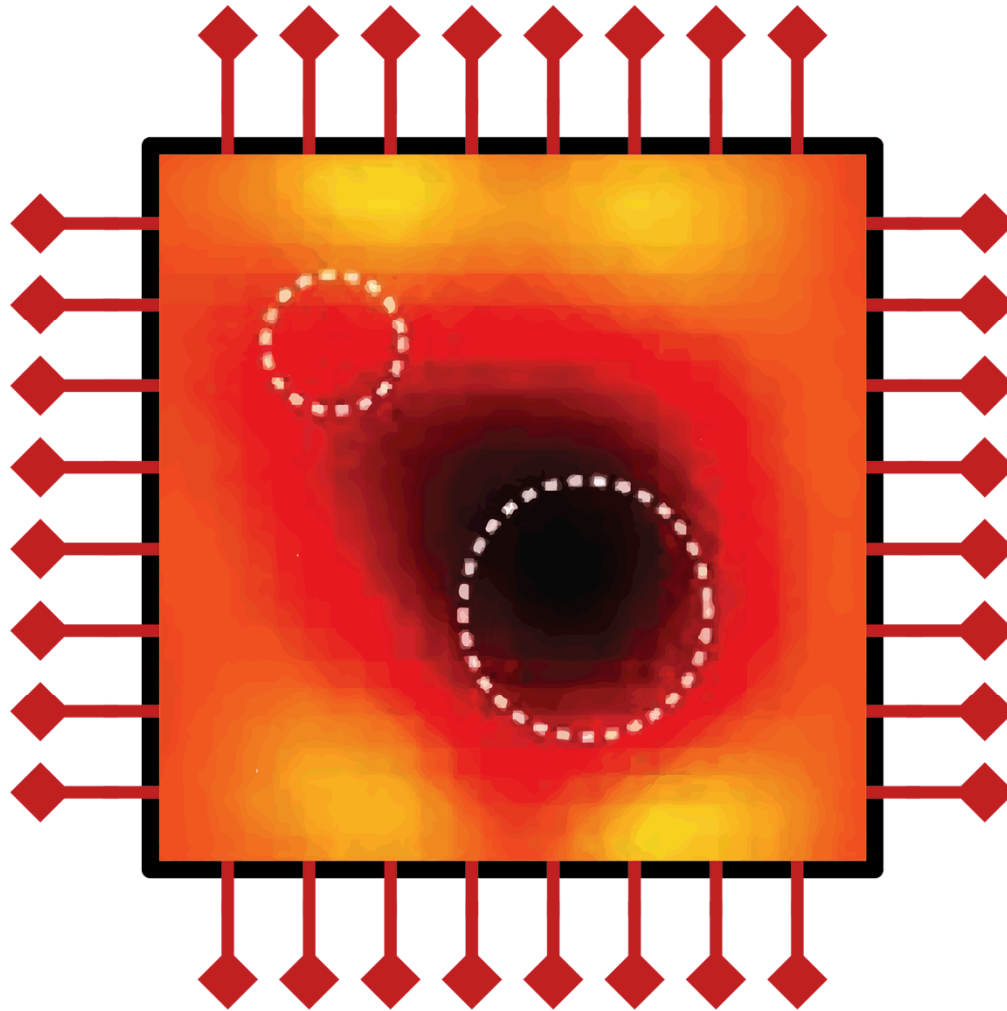
EIT Measurement:

32 current injections
x 32 nodes

1024 voltage
measurements

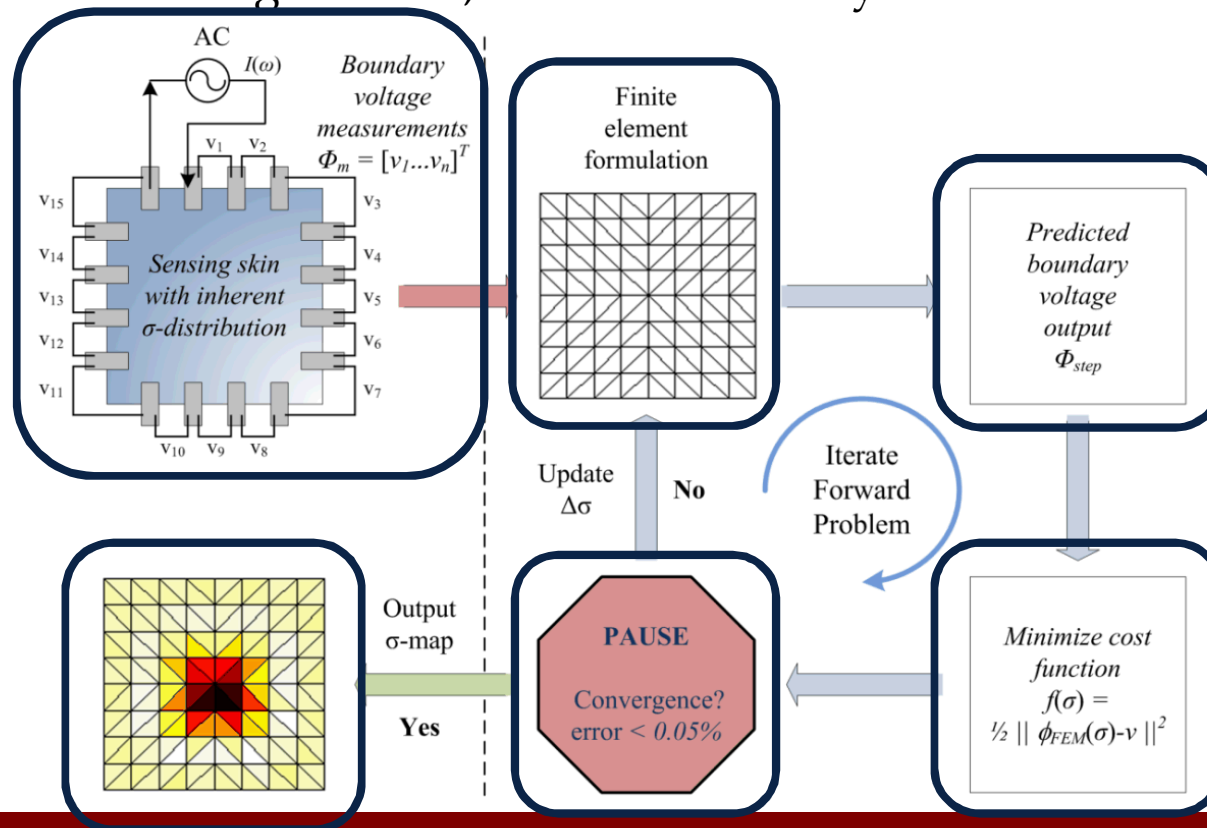






Typical EIT Reconstruction

- Laplace's equation:
 - $\nabla \cdot (\sigma \nabla \phi) = 0$, where σ can vary by orders of magnitude
 - Governs potential and conductivity relationship
- Forward problem: conductivity known, solve voltage
- Inverse problem: voltage known, solve conductivity



- Reconstructs small σ changes:

- Typically difference imaging

- $\sigma_1 - \sigma_2 \ll \sigma_2$

- Maximum a posteriori (MAP):

- H: sensitivity matrix

$$H(\sigma_{bgd})_{ij} = \frac{\partial V_i}{\partial \sigma_j}$$

- Regularization hyperparameter: λ

- Noise figure

$$NF(\lambda) = \frac{SNR_{in}}{SNR_{out}} \approx 1$$

- Use representative σ distribution

- W: Noise model

- R: Regularization matrix

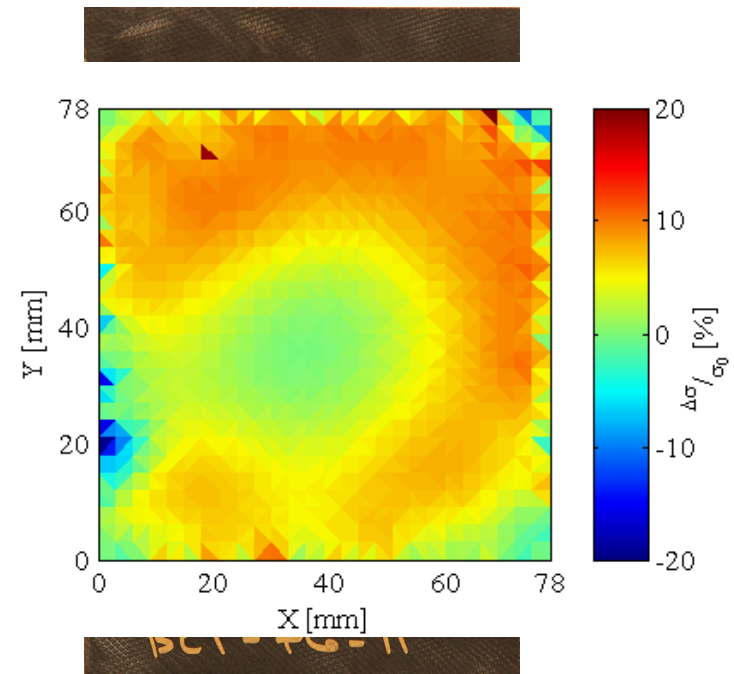
- Advantages:

- Can pre-calculate H

- Many damage modes lead to small changes in σ

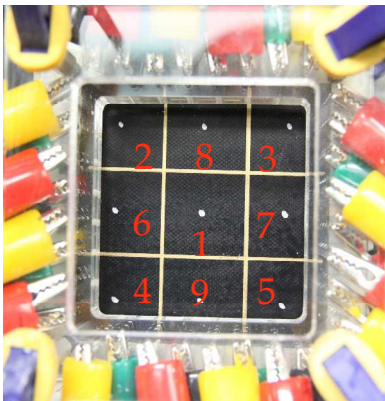
$$\frac{\Delta \sigma}{\sigma_0} = \left(\underline{H}^T \underline{W} \underline{H} + \underline{\lambda} R \right)^{-1} \left(\underline{H}^T \underline{W} \right) \frac{\Delta V}{V_0}$$

$$\frac{\Delta \sigma}{\sigma_0} = B \Delta \frac{\Delta V}{V_0}$$



Spatially Distributed Sensitivity

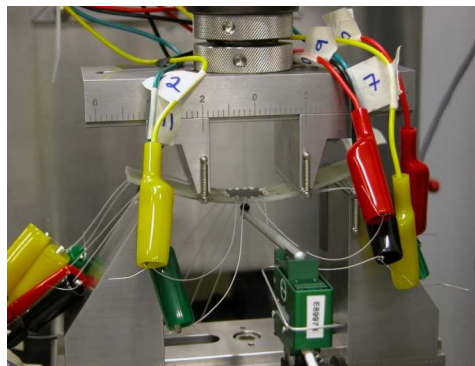
- Understand sensitivity to prescribed damage w.r.t. spatial position in sensing area
- 9 holes distributed across specimen
- 6.35 mm diameter



Spatially Distributed Sensitivity Specimen

Spatially Distributed Strain Sensitivity

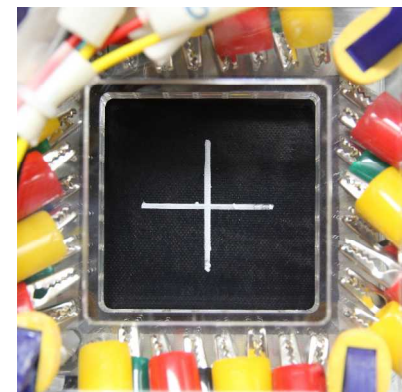
- 4-pt bending specimens
 - Homogeneous strain between inner supports
- Tensile and compressive strain values
- Small changes in conductivity



Spatially Distributed Strain Sensitivity Specimen

Damage Size Sensitivity

- Understand sensitivity to increasing damage at center of specimen
- Least sensitivity point in sensing region
- 6 progressively larger holes
 - $\frac{1}{16}''$, $\frac{1}{8}''$, $\frac{3}{16}''$, $\frac{1}{4}''$, $\frac{5}{16}''$, $\frac{3}{8}''$

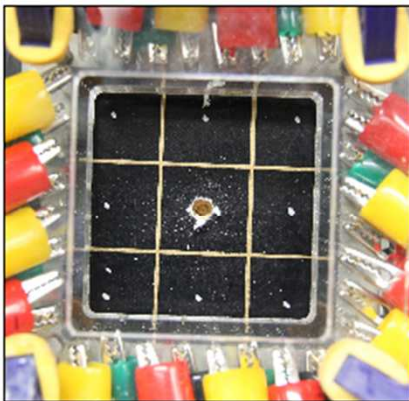


Damage Size Sensitivity Specimen

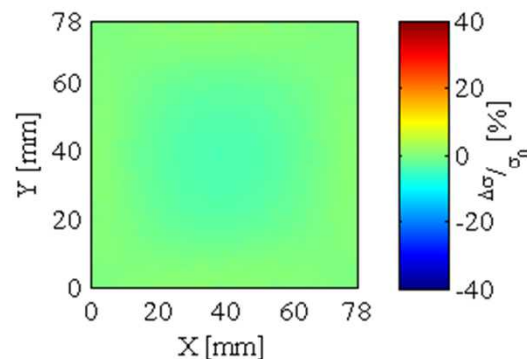
Spatially Distributed Sensitivity

- EIT Response

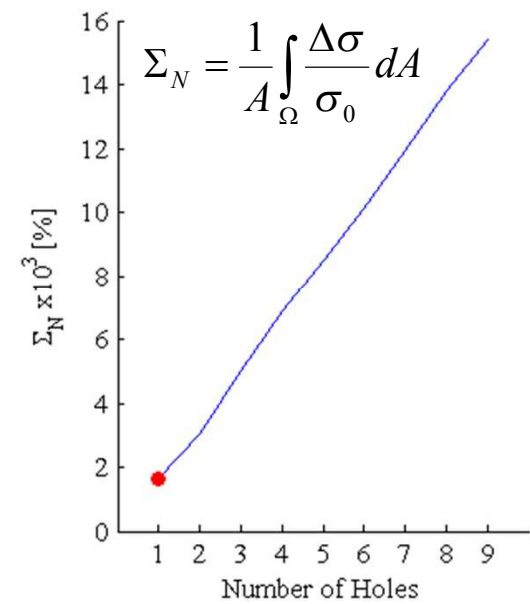
- Consistent cumulative amplitude response
 - Linear response to increasing sustained damage
- Further from center, response more disperse
 - Mean response at correct damage location



Specimen



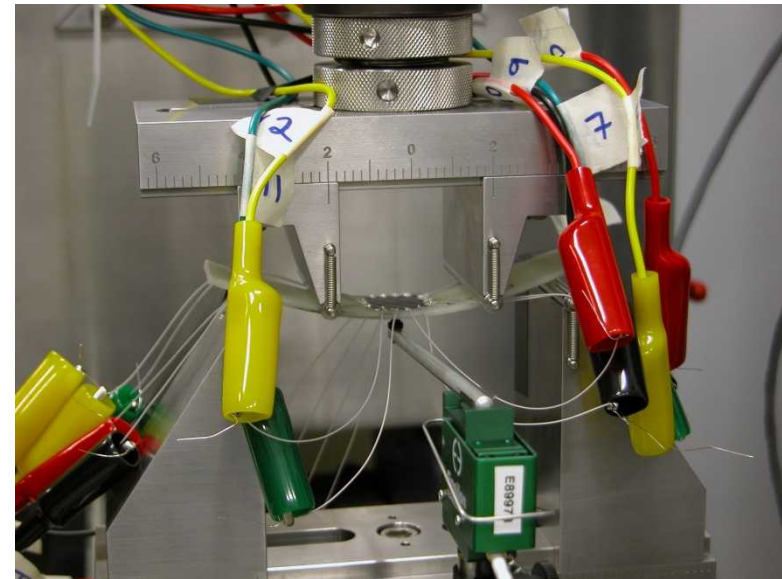
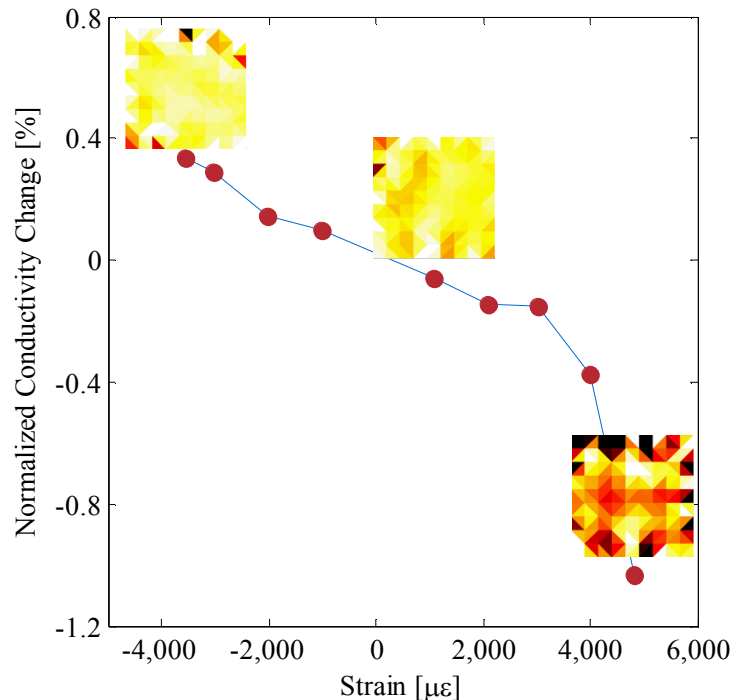
EIT Response



Damage Metric

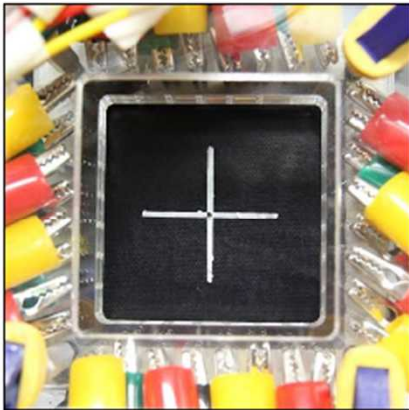
Spatial Strain Sensing

- 4-pt bending
 - ASTM D7264
 - MWNT-Latex on GFRP
 - Stepped displacement profile
 - Tensile/compressive strain
- Strain sensitivity
 - Nearly linear

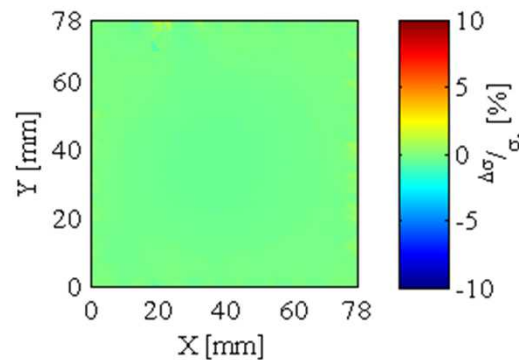


Damage Size Sensitivity

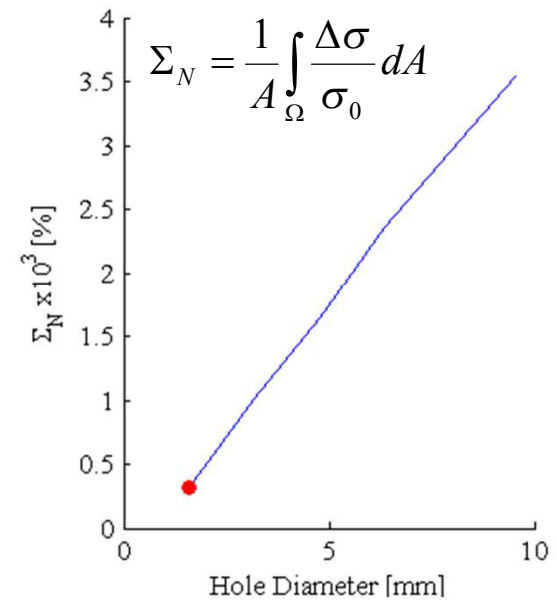
- EIT Response
 - Increasing EIT response to increasing damage size
 - Nearly linear response to size
 - EIT response at corresponding location to damage but response size is exaggerated



Specimen



EIT Response



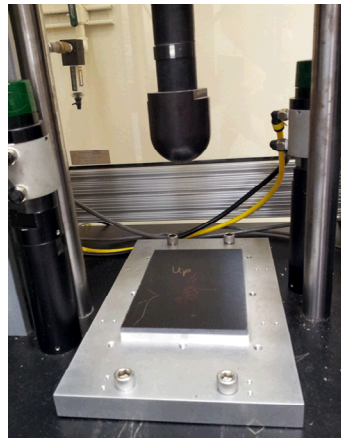
Damage Metric

Impact Damage Detection

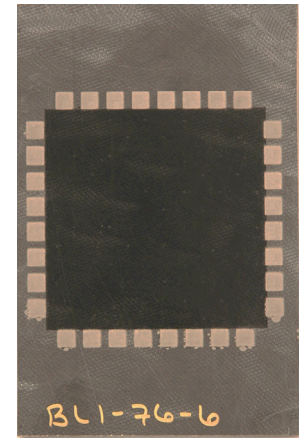
- Drop-weight impact tests
 - ASTM D7146
 - 78 mm by 78 mm sensing region
 - MWNT-latex on glass fiber weave
 - Impact energy: 20, 60, 100, 140 J
 - Before/after EIT measurements
- Verification:
 - Photographic Imaging
 - Surface damage



Drop-weight impact tester



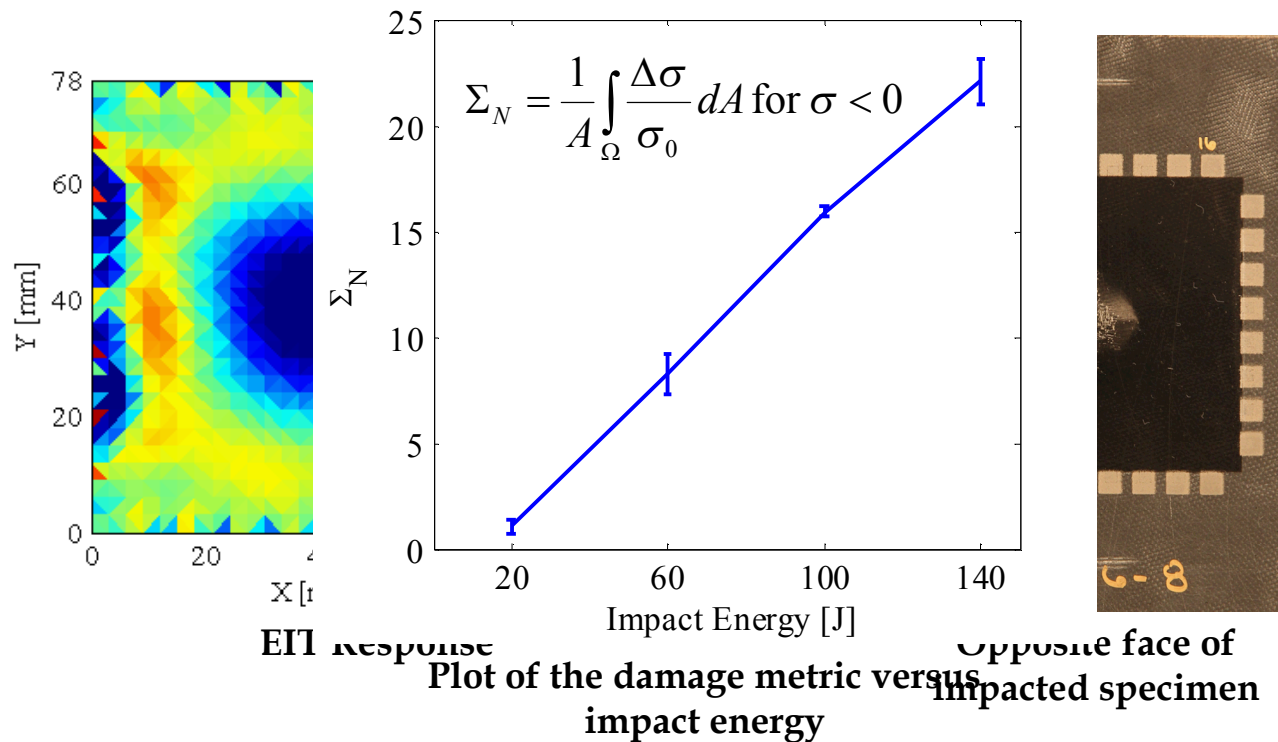
Impact setup



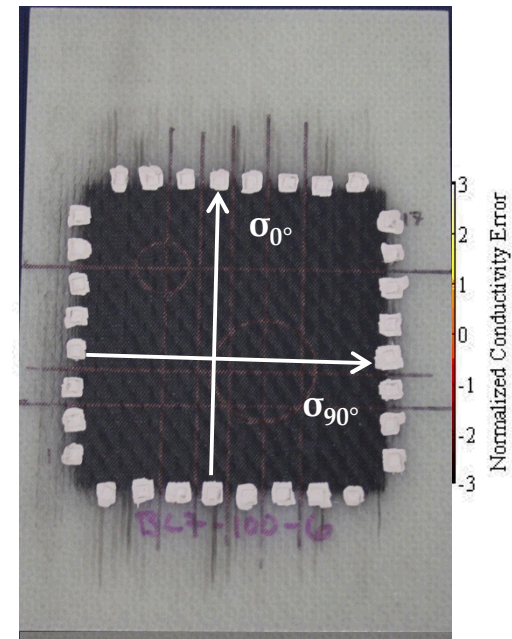
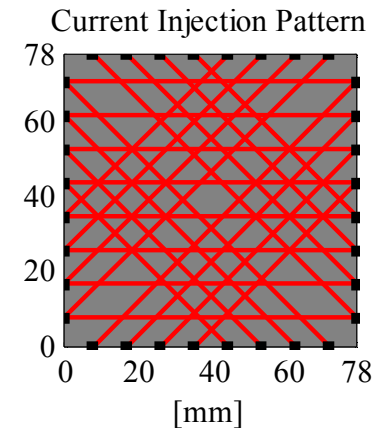
Impact specimen

Impact Damage Detection

- EIT reconstruction captures conductivity decrease in damaged region
 - Decreasing amplitude and increasing response region with increase in impact energy
- Linear response w.r.t. damage metric with good repeatability

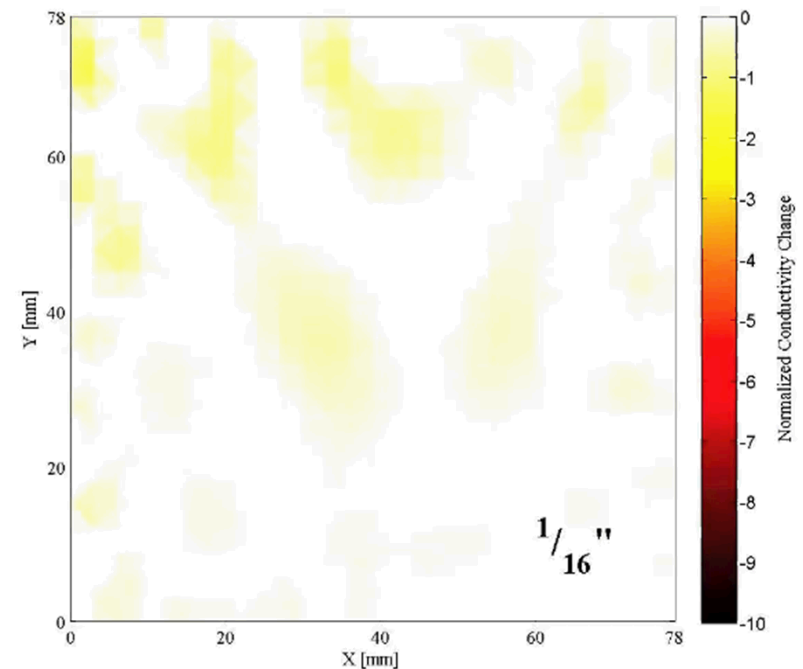
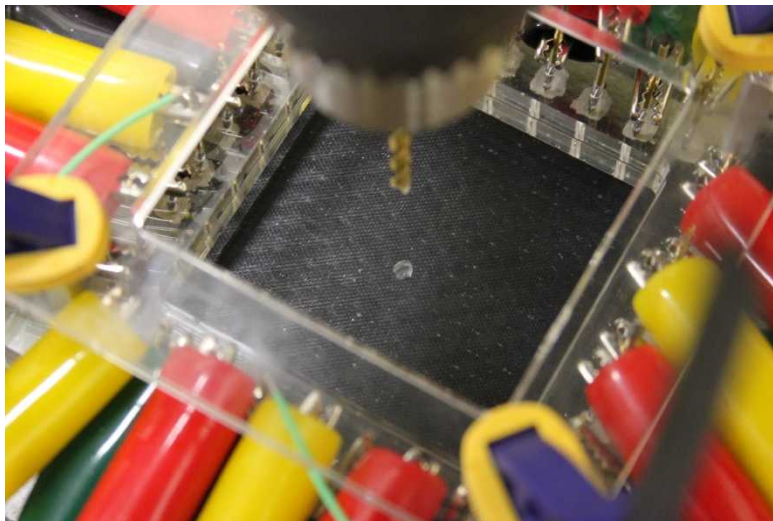


- Embedded sensing architecture
 - MWNT-Latex on GF fiber weave
 - Embedded within epoxy matrix
- Specimens
 - $[0^\circ/+45^\circ/90^\circ/-45^\circ]_{2s}$
 - Unidirectional GF
 - 150 mm x 100 mm
 - ASTM D7146 Standard
- Anisotropic EIT
 - Isotropic ► Anisotropic
 - Scalar ► Matrix: σ
 - $\sigma_{0^\circ} > \sigma_{90^\circ}$ by $\sim 2:1$
 - $\nabla \cdot (\sigma \nabla \phi) = 0$



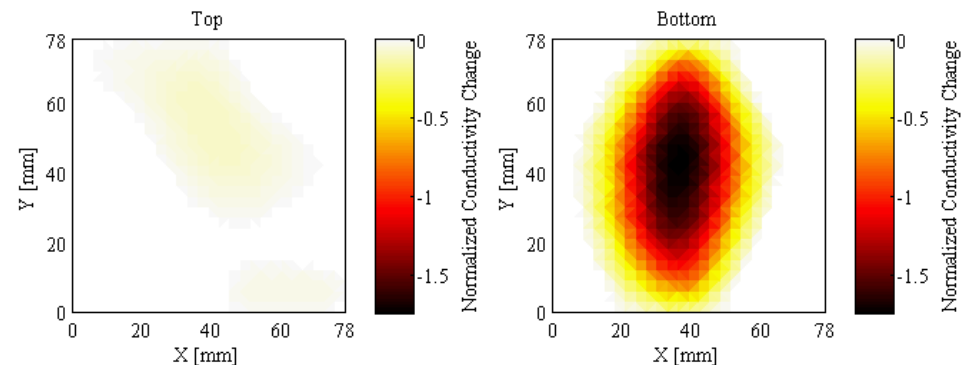
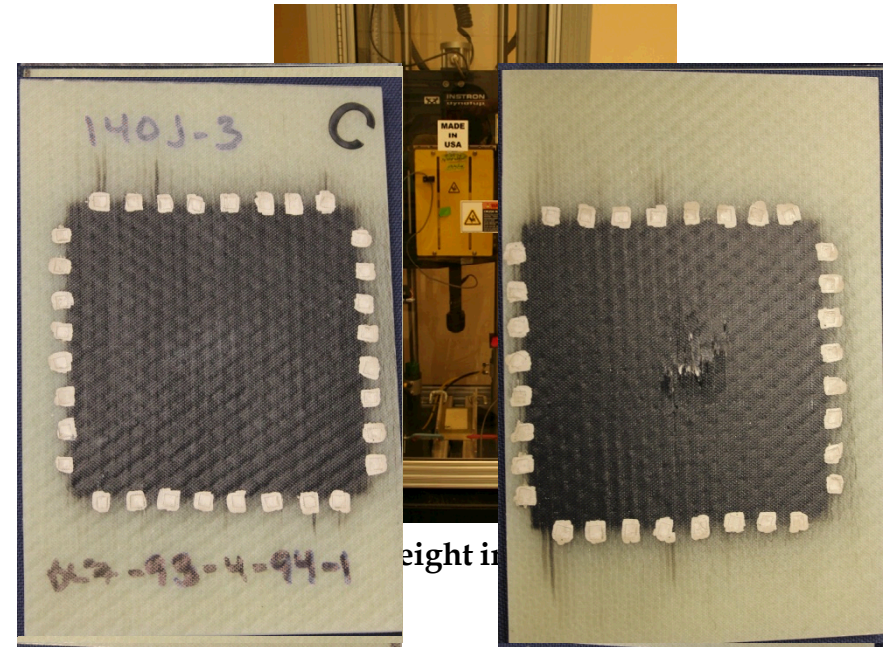
Embedded Spatial Sensitivity

- Embedded sensing validation:
 - Determine conductivity change sensitivity
 - Process:
 - Progressively larger drilled holes:
 - $1/16''$, $1/8''$, $3/16''$, $1/4''$, $5/16''$, $3/8''$, $1/2''$
 - Anisotropic EIT performed
 - Conductivity change from pristine sample



Impact Damage Detection

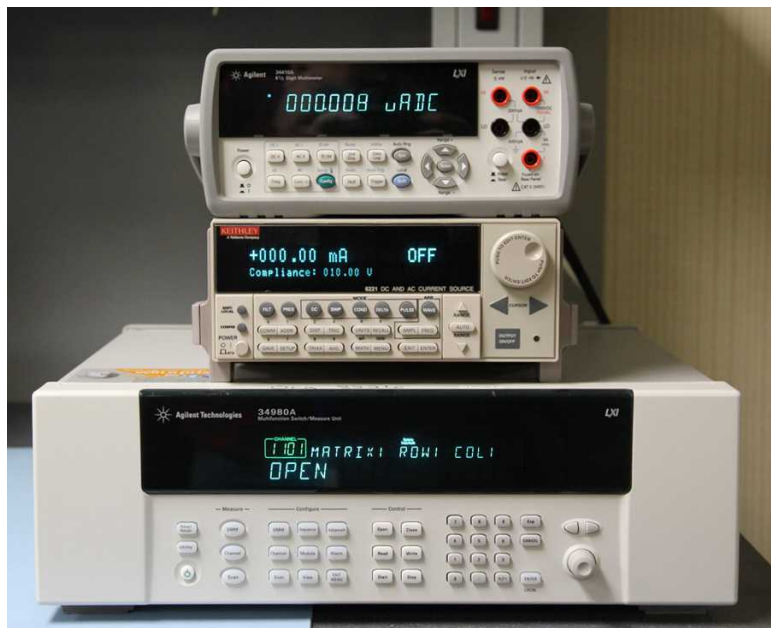
- Drop-weight impact tests
 - ASTM D7146
 - 78 mm by 78 mm sensing region
 - MWNT-latex on glass fiber weave
 - Impact energy: 20, 60, 100, 140 J
 - Before/after EIT measurements
- Verification:
 - Thermography
 - Matrix Cracking
 - Delamination
 - Photographic Imaging
 - Surface damage



EIT DAQ System and the Utah Clinic

Original DAQ Design

- 90 seconds/EIT measurement
 - 11 voltage measurements/sec.
- ~\$9,500
- 430 in² (~50 lbs)
 - Difficult to scale



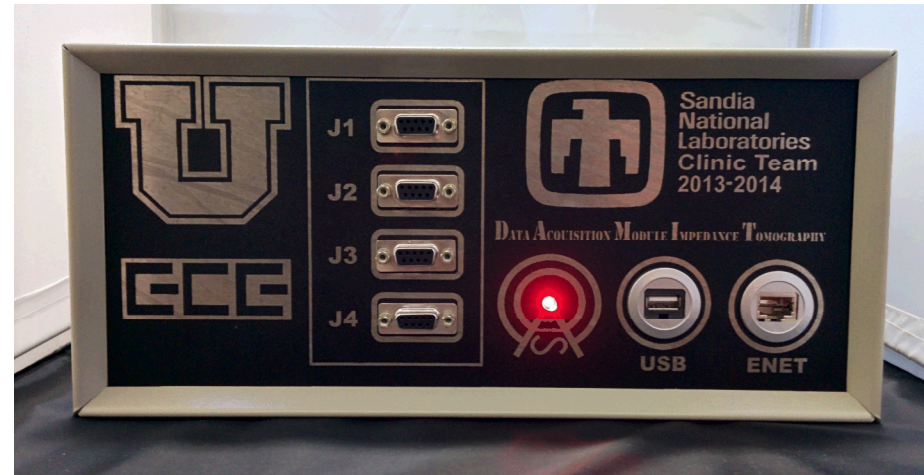
Agilent digital multimeter
Keithley current source
Agilent multifunction switch/measure unit

Senior Design Project Goals

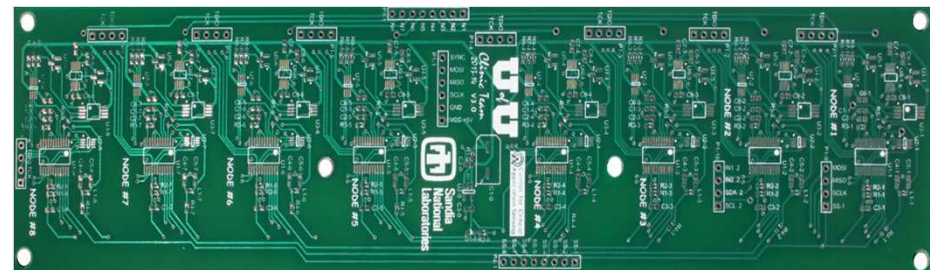
- 100 EIT measurement/sec.
 - 100k voltage measurements/sec.
- Modular (+32 nodes)
 - Unit cost < \$1,000
- Graphical User Interface (GUI)
 - User defined current injection pattern
- Adjustable current source between
1 μ A to 100 mA
- Enclosure – field testing
- Project budget: \$3,000

Utah Clinic 2013-2014

- Version “0”
- 32 node design
 - Completely parallel system
 - Each node:
 - Current source
 - Ground
 - ADC for voltage measurement
- Speed: Never tested
- Cost: ~\$1300

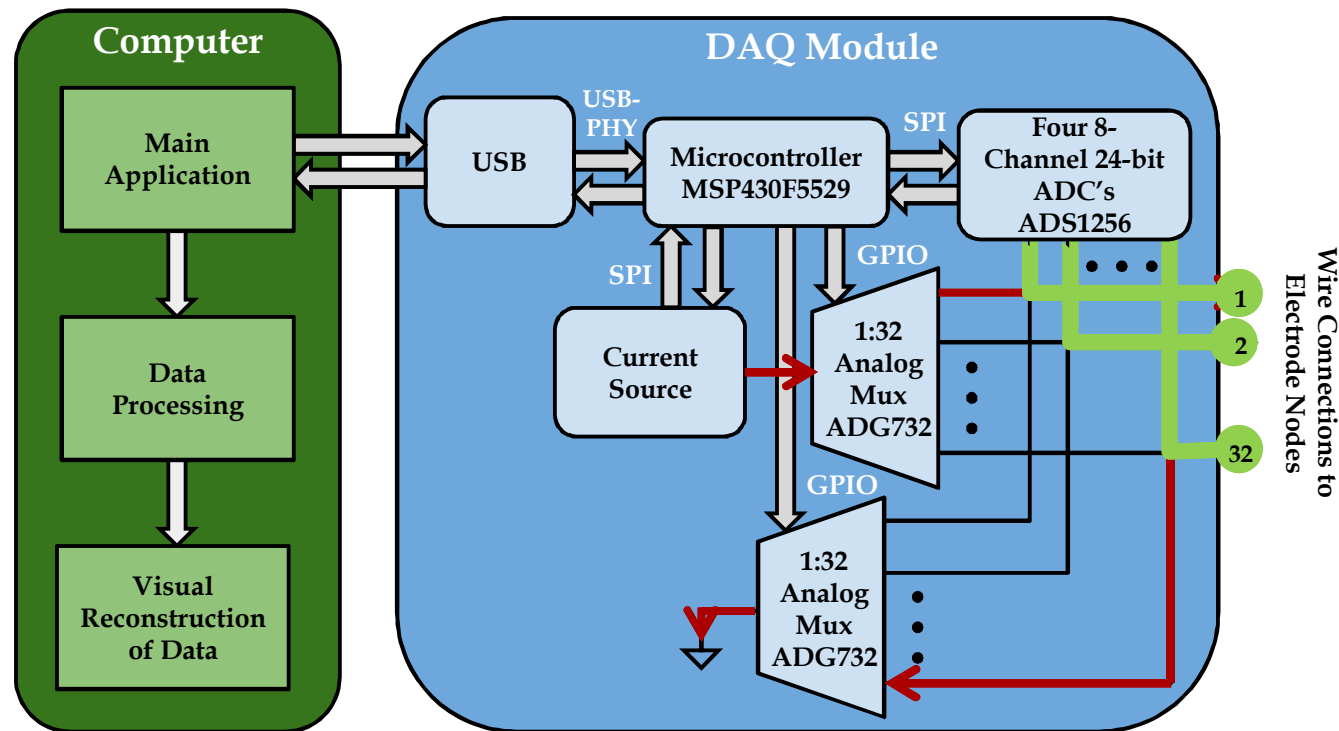


EIT DAQ in Aluminum Enclosure

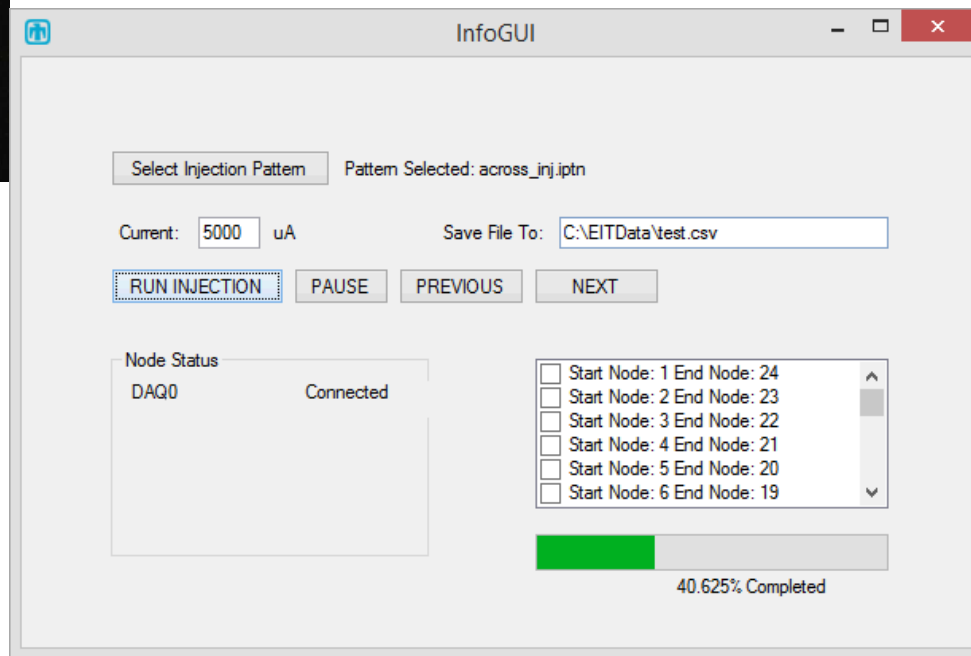
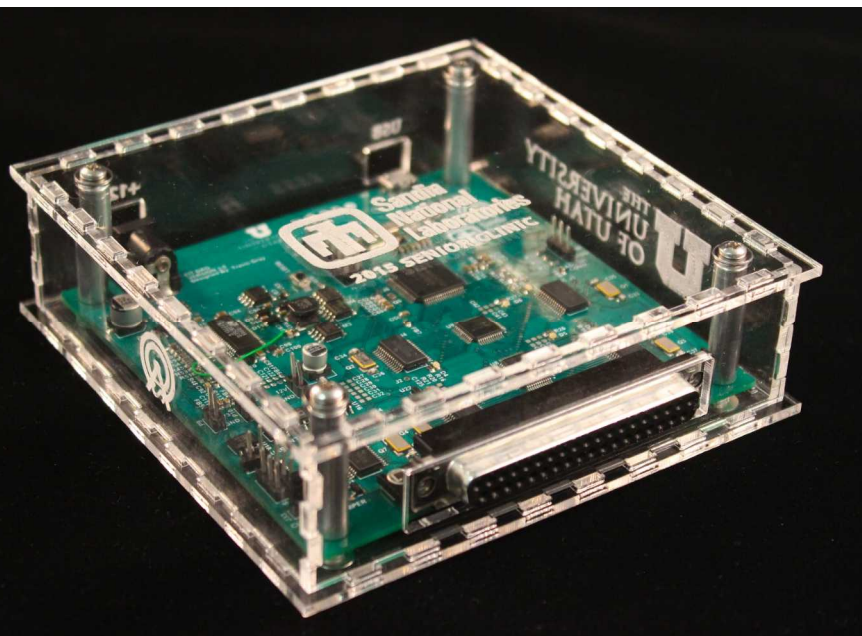


EIT DAQ PCB Board (1 of 4)

- Versions: 1 and 2
- Multiplexed design
 - 32 nodes per DAQ
 - Ground and current injection set to assigned electrodes
 - Voltage measurements are multiplexed amongst remaining nodes
- Up to 8 DAQs can be connected to each computer
 - Up to 256 nodes
- Speed: 1.8s per EIT measurement
- Cost: \$422



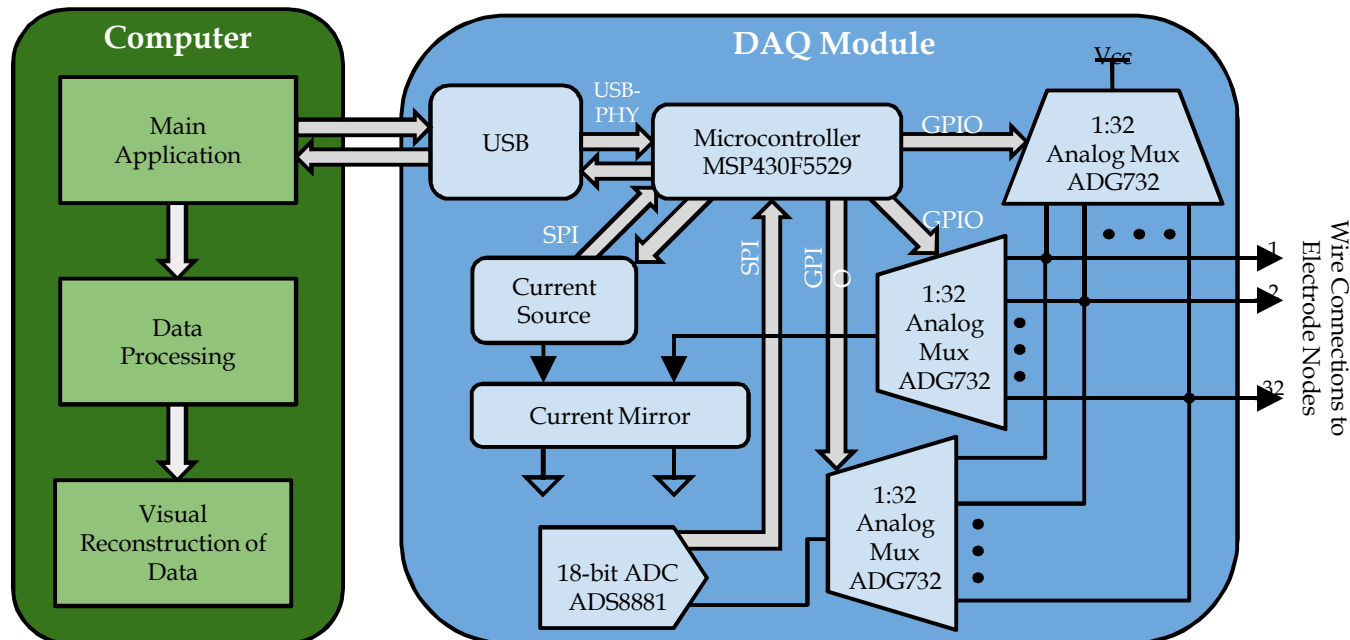
Utah Clinic 2014-2015



Summer Internship 2015

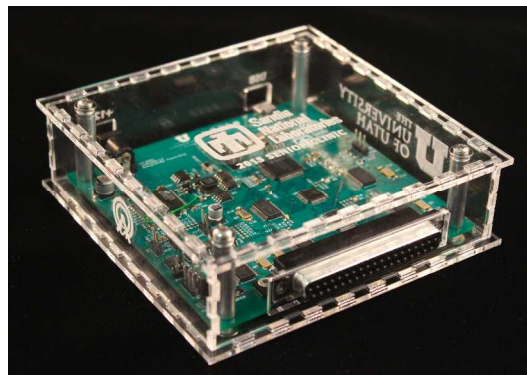
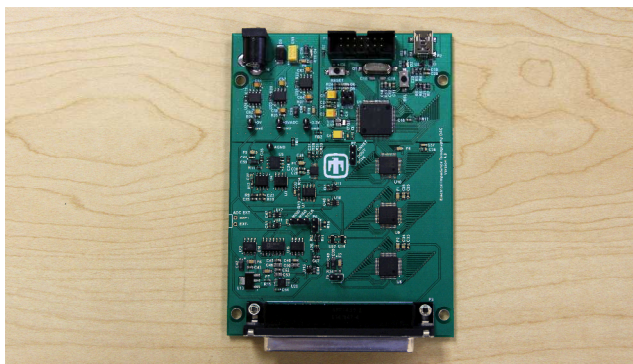
- Versions: 3.0, 3.1, 4.0, and 4.1
- Updates:
 - Lower noise voltage measurements
 - Smaller footprint
 - Lower power
 - Improved design for speed

Version	Supply	Ripple (V_{pk-pk})	Noise (V_{rms})
3.0	5 V	230 mV	43 mV
	3.3 V	19.9 mV	3.45 mV
3.1	5 V	3.55 mV	1.55 mV
	3.3 V	2.93 mV	827 μ V



Version Comparisons

	Version 4.0	Version 3.0	Original Setup
EIT Measurement	est. 1 ms	1.8 sec.	90 sec.
Voltage Measurements	est. 100k per sec.	11.2k per sec.	11.4 per sec.
Unit Cost	\$252	\$422	~\$9,500
Current Source	est. 10uA – 100mA	10uA – 10mA	100fA – 105mA
GUI	Yes	Yes	No
Area Footprint (Weight)	15 in ² (<1 lb)	16 in ² (<1 lb)	430 in ² (~50 lbs)
Communication	USB	USB	USB
Power	est. 0.6 W	0.5 W	+10W



Thank You!

Questions?

Acknowledgements:



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